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# Recent developments in compound semiconductor radiation imaging detectors

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# Introduction

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A review of recent developments in semiconductor detector materials and technology for X-ray and gamma imaging:

□ **Commercially available or near-market materials:**

- status of CdZnTe/CdTe
- summary of best spectroscopic results from other materials
- INTEGRAL/SWIFT – imaging detectors in space

□ **New developments in large-area thick film materials:**

- polycrystalline and epitaxial CdZnTe/CdTe thick films
- Heavy element ( $Z \geq 80$ ) thick films (Hg, Tl, Pb, Bi)

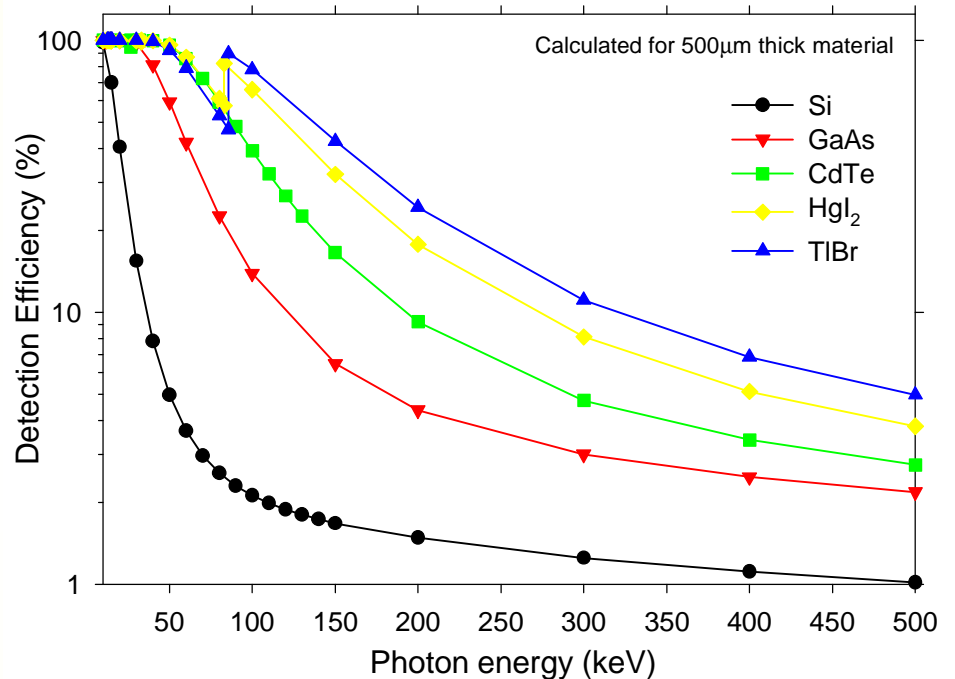
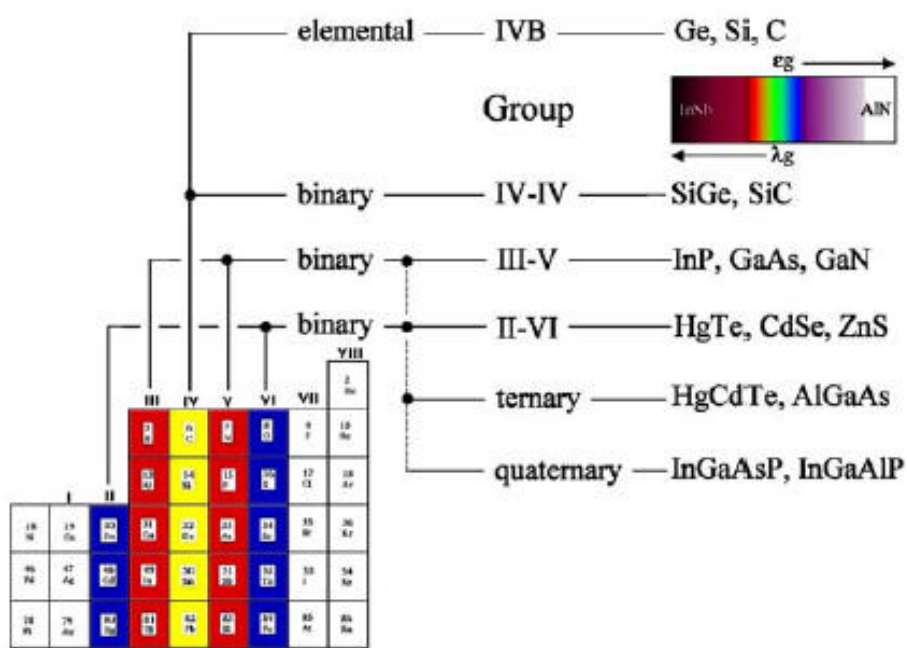
□ **Future materials** – latest results from promising candidate materials:

- CdMnTe
- GaN
- Synthetic diamond

□ **Conclusion**

# Commercially available or near-market materials

Commercially available material continues to be predominately CdZnTe, plus CdTe and GaAs.

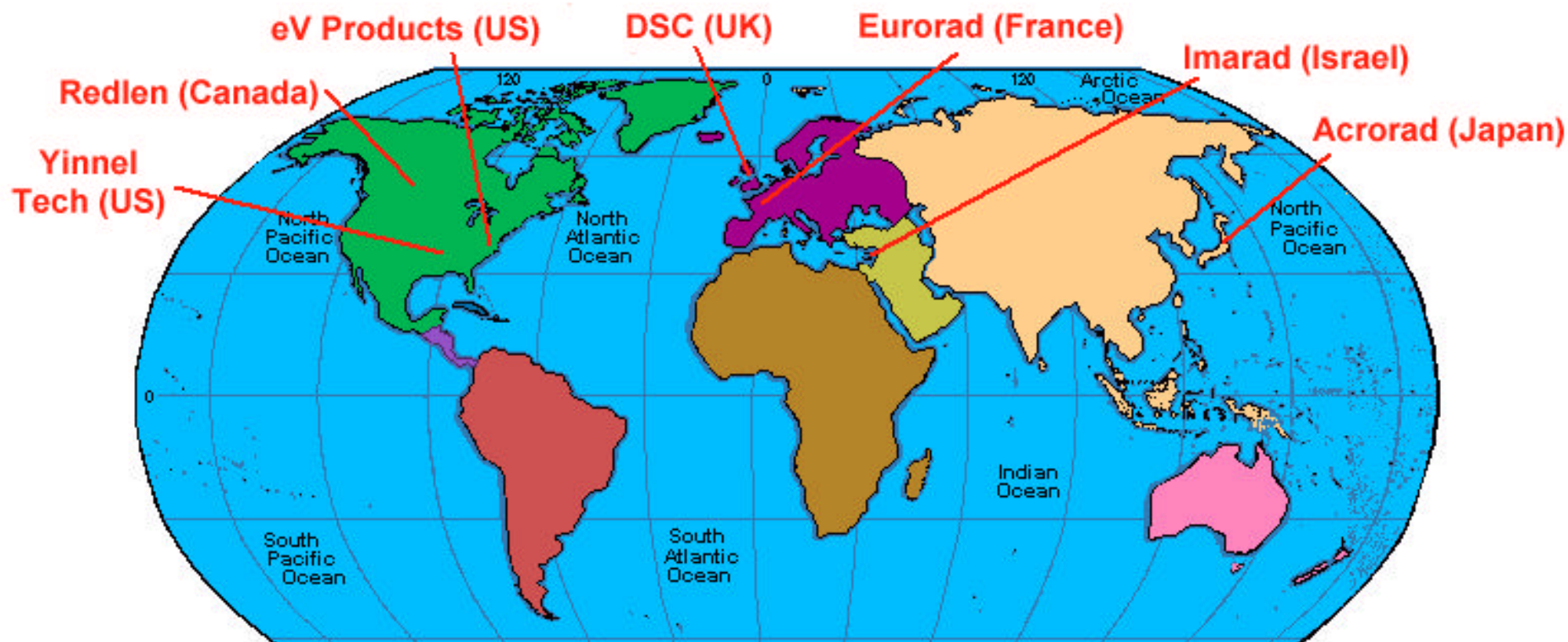


- ❑ II-VI materials CdTe and CdZnTe cover a suitable range of band gaps:  
1.44 eV (CdTe), 1.57 eV (CdZnTe, 10% Zn), 1.64 eV (CdZnTe, 20% Zn)
- ❑ Resistivity of CdZnTe is higher than CdTe ⇒ lower dark current, higher spectroscopic resolution
- ❑ Poor hole transport requires electron-sensitive detector geometries

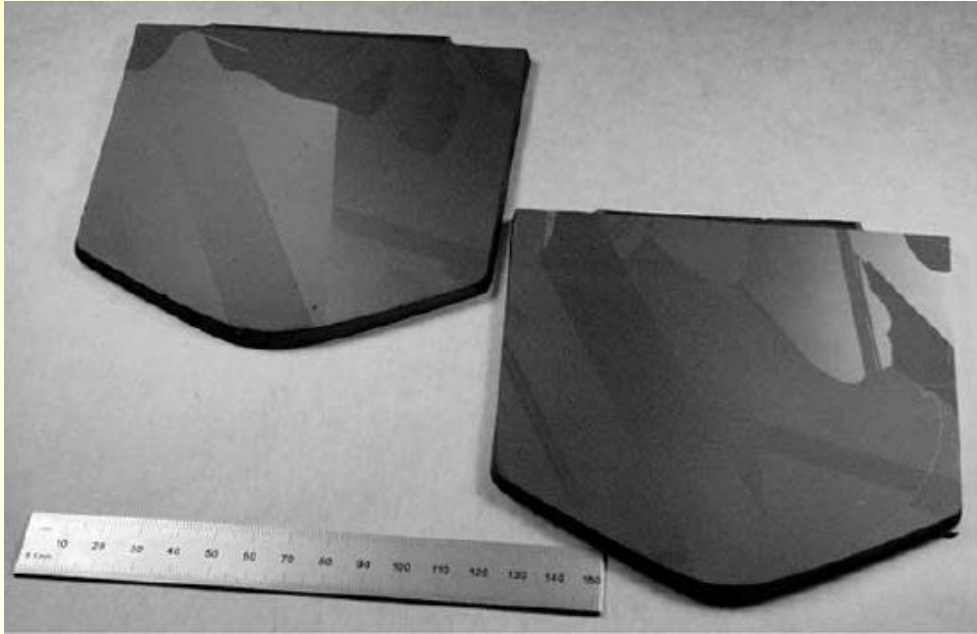
# Commercial suppliers of CdTe/CdZnTe

eV Products continues to be the lead supplier of CdZnTe, grown using various Bridgman techniques:

- ❑ High Pressure Bridgman (HPB): 1992
- ❑ High Pressure Gradient Freeze (HPGF): 1998
- ❑ High Pressure Electro-Dynamic Gradient (HP-EDG): 2000
  - Electronic heating control, stationary crucible/heater
  - Reduced thermal stress, less cracking, better single crystal material



# CdZnTe ingots grown by HP-EDG

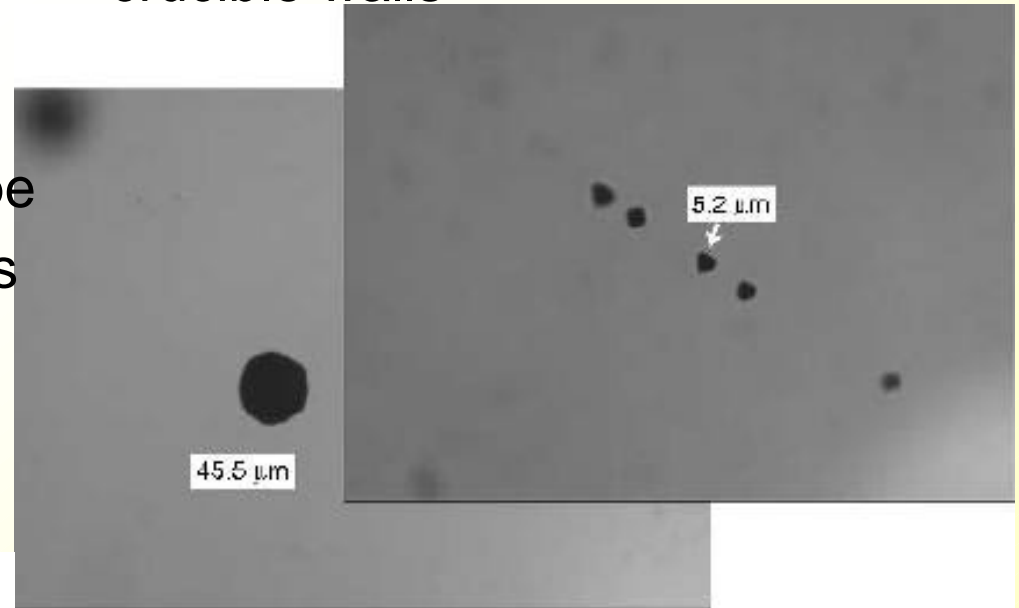


Latest published results from eV Products show 10kg crystals, 140mm (5.5 inch) diameter:

- No cracking
- Large-grain polycrystalline, with improved single-crystal yield
- Reduced concentration of twins
- Secondary grain nucleation on crucible walls

IR microscopy used to assess Te inclusions, formed from Te-rich melt:

- Mainly triangular or polyhedron shape
- Often located along grain boundaries and
- Te inclusions act as trapping sites, over a large range

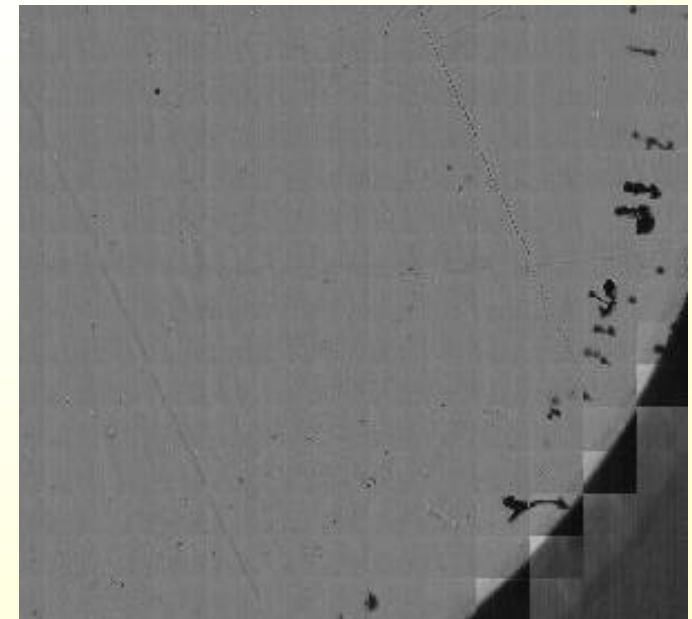
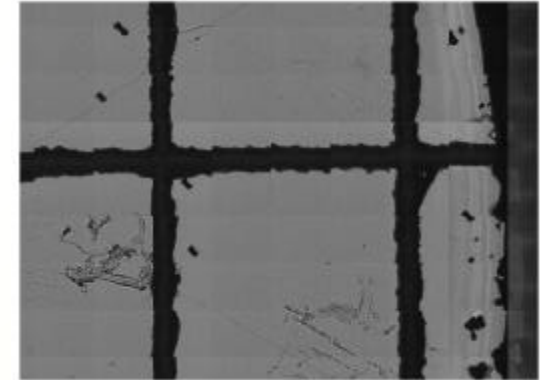
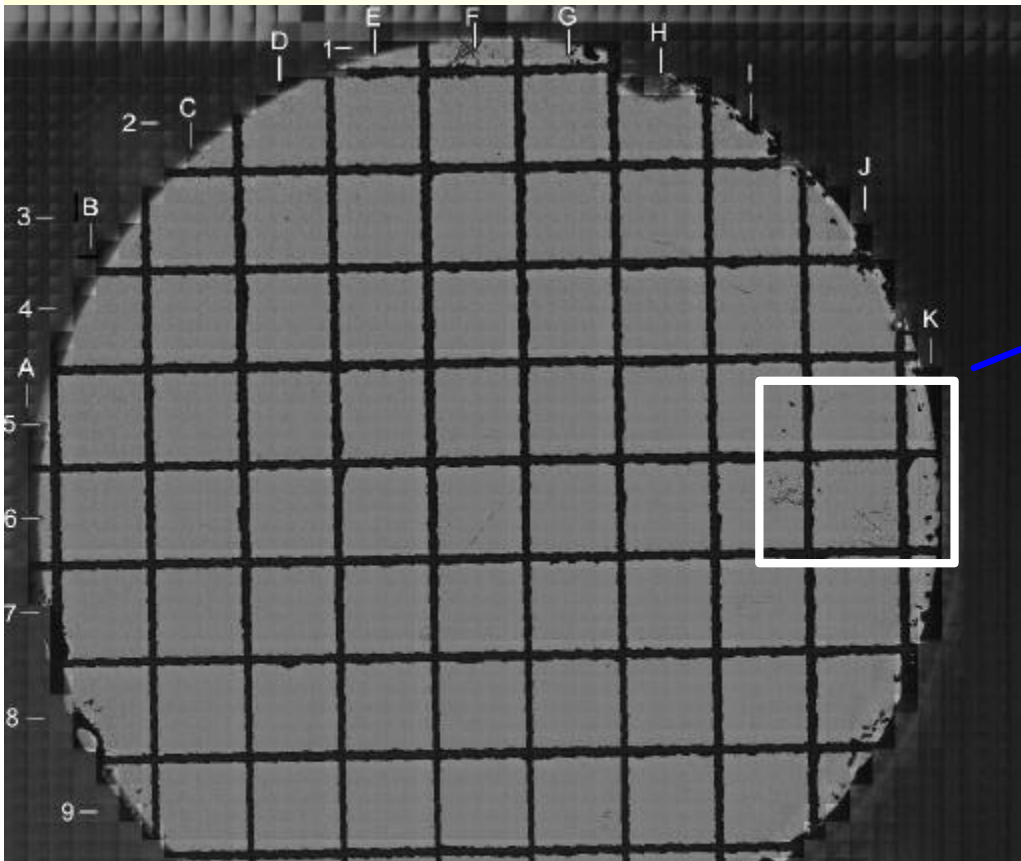




# Tellurium inclusions in CdTe

CdTe has also been studied using IR microscopy – presence of Te inclusions causes:

- ❑ Non uniform signal response
- ❑ Decreased electron drift length, low mobility

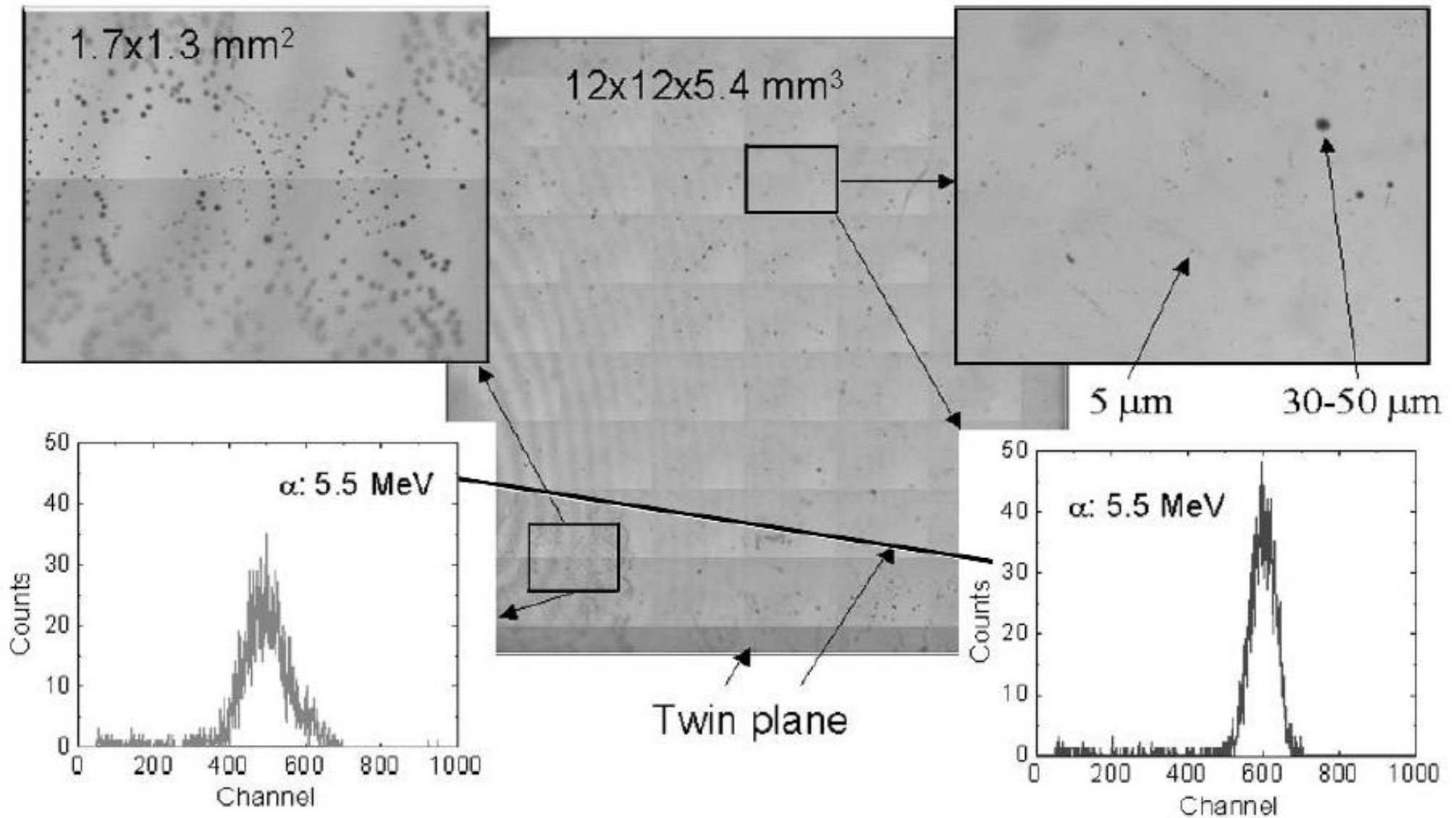


25mm diameter CdTe wafer, scribed with locating grid lines prior to metal deposition

Paul Sellin. Centre for Nuclear and Radiation Physics

A. Davies, P.J. Sellin et al, IEEE Trans Nucl Sci, in press

# Te inclusions in HP-EDG CdZnTe



# Charge transport performance in CdZnTe

Carrier drift length  $\lambda$  defines the induced charge  $Q$ , and hence the spectroscopic performance of the detector:

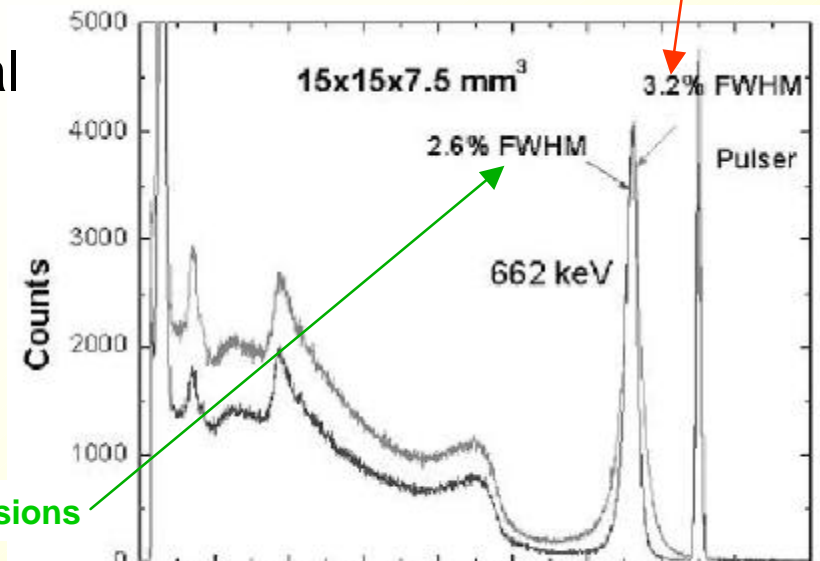
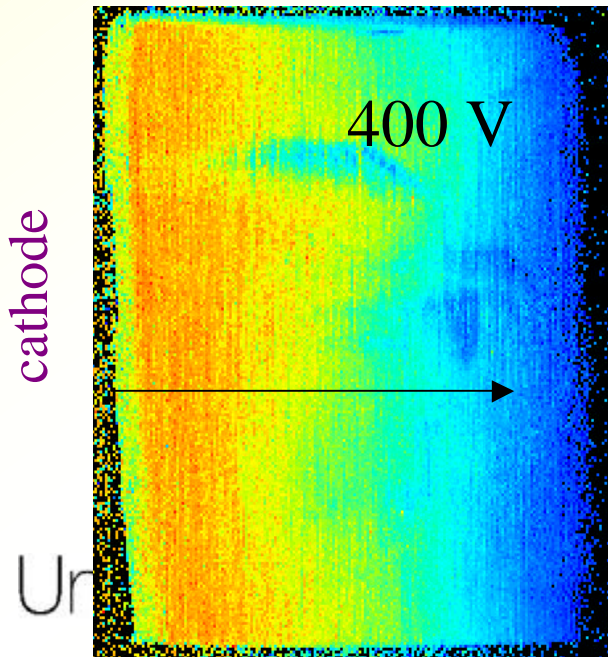
For electrons: 
$$CCE = \frac{Q}{Q_0} \approx \frac{I_e}{d} \left( 1 - \exp\left(\frac{-d}{I_e}\right) \right)$$

HP-EDG material gives  $\mu\tau_e$   
 $\sim 5 \times 10^{-3} \text{ cm}^2/\text{V}$  – some of  
 the best values available

The mobility-lifetime product  $\mu\tau$  is often used as a measure of charge transport quality:  $I_e = \mu t E$

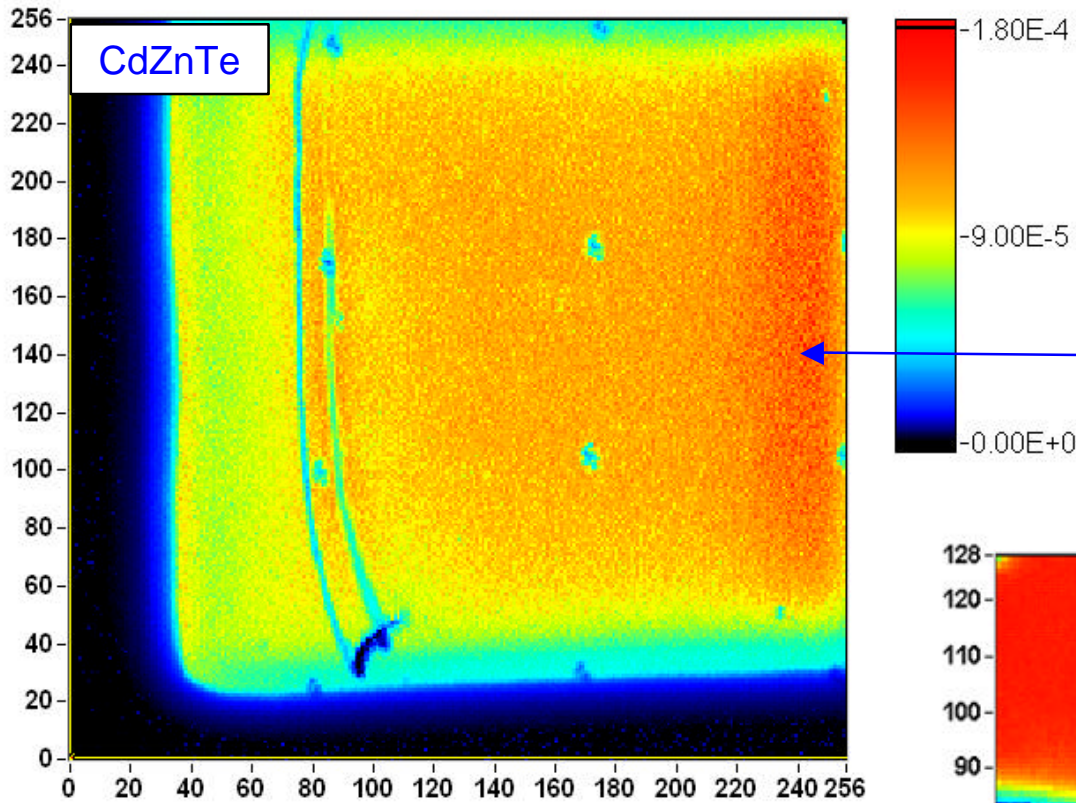
- $\mu\tau$  mapping using focussed MeV proton beams demonstrates depth-dependent gain

- HP-EDG material shows high non-uniformity of response due to Te inclusion density



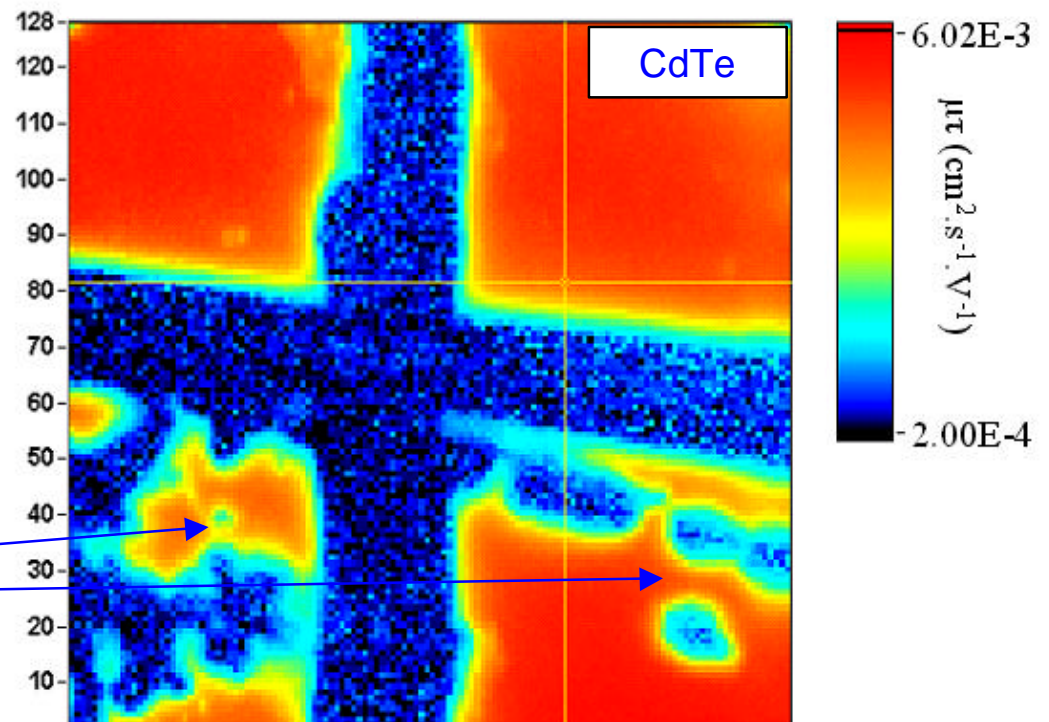


# Ion beam $\mu\tau$ maps of CdZnTe and CdTe



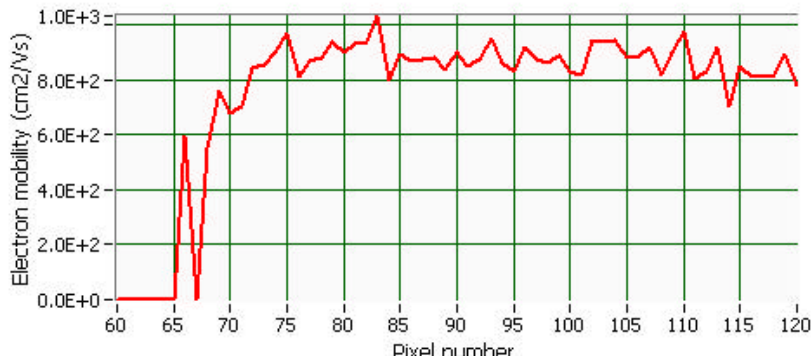
Map of electron  $\mu\tau$  in CdZnTe shows  $\mu\tau_e \sim 1 \times 10^{-4} \text{ cm}^2/\text{V}$   
Highly uniform, no evidence of defects in 'single crystal' material  
Increased  $\mu\tau$  at right edge due to beam scanning

CdTe electron  $\mu\tau$  map shows  $\mu\tau_e \sim 5 \times 10^{-3} \text{ cm}^2/\text{V}$   
Pixel detector shows problems with contact delamination in lower quadrants

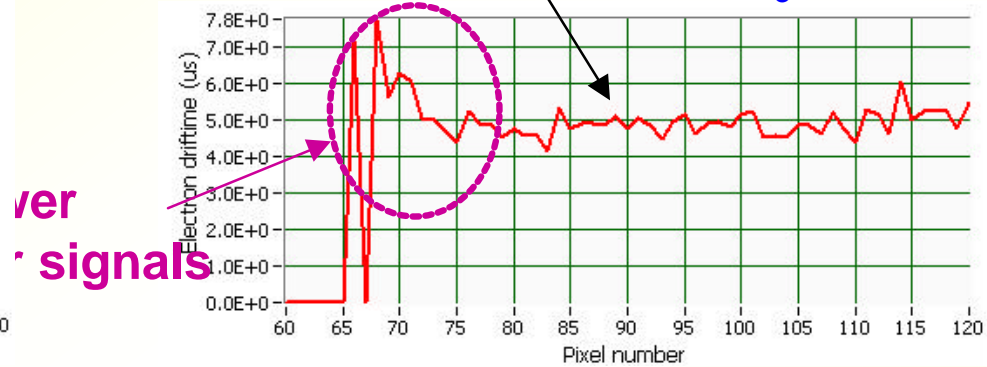


# Amplitude and drift time maps in CdTe

Zoom into corner of CdTe sample – uniform region,  $\tau_e \sim 5.0 \mu\text{s}$   $V = 150\text{V}$ ,  $d = 8\text{mm}$ ,  
 $\mu_e \sim 850 \text{cm}^2/\text{Vs}$

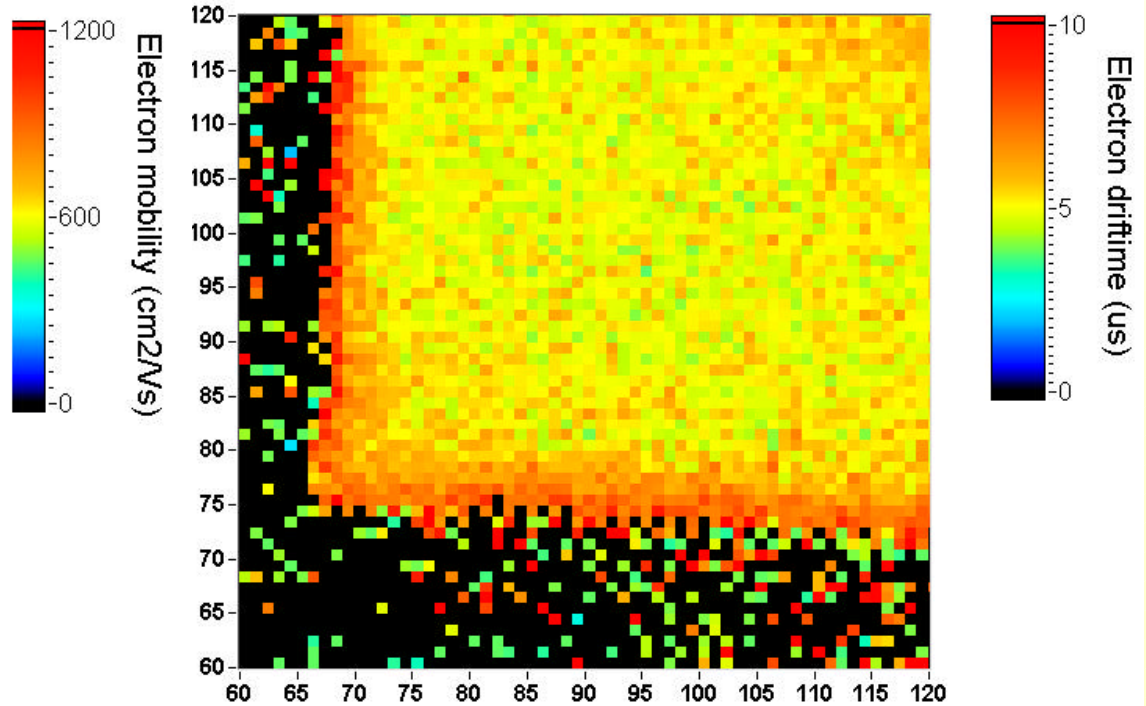
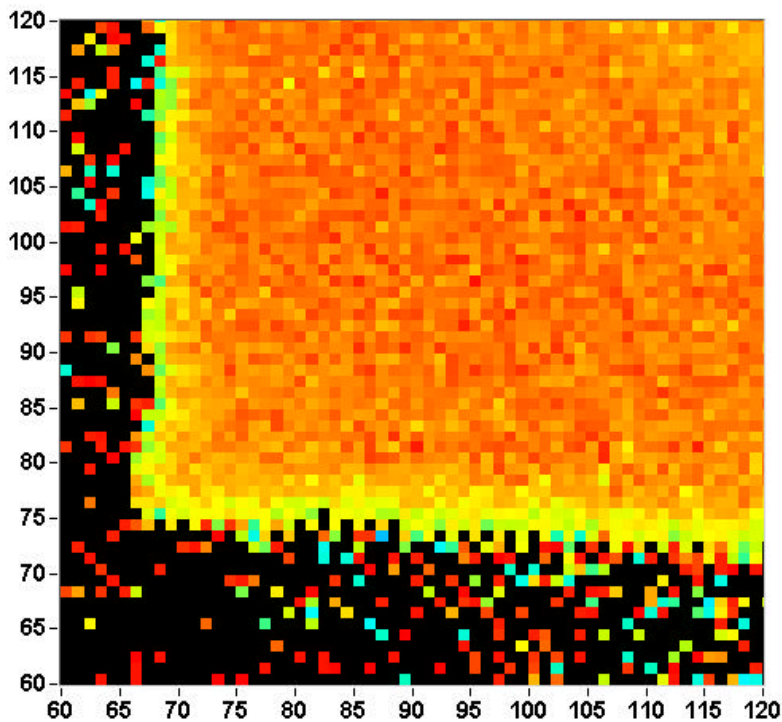


Electron mobility



ver  
signals

Electron drift time

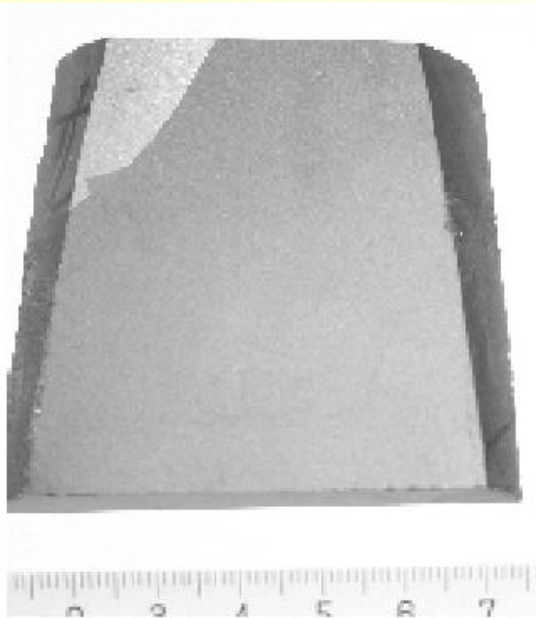




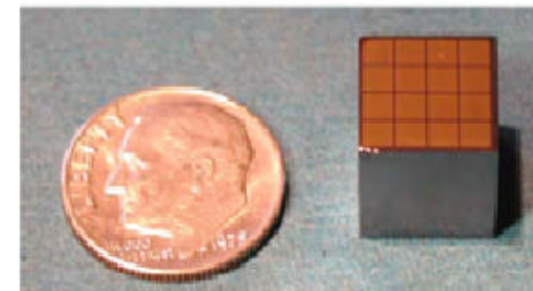
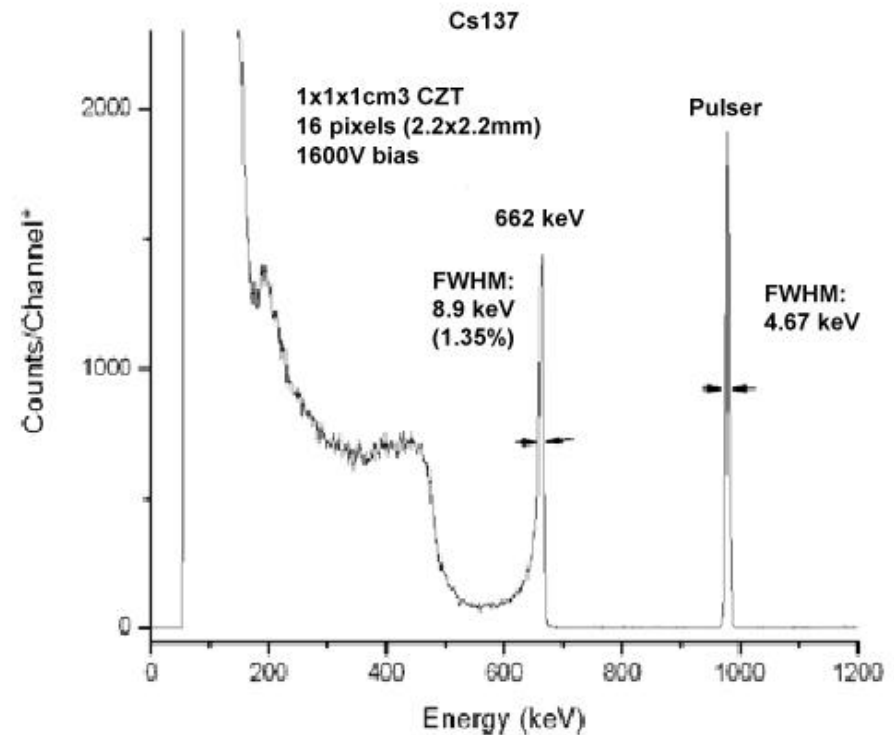
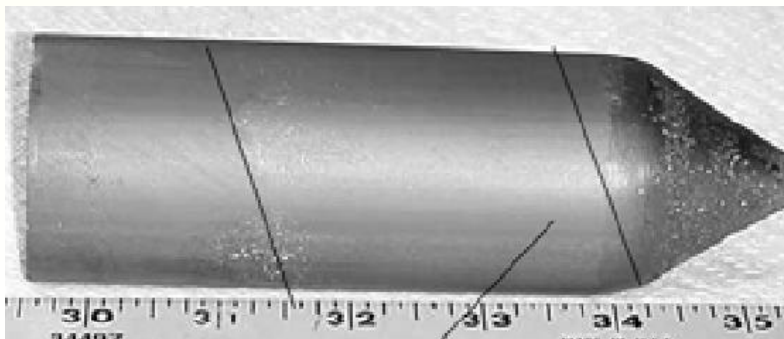
# CZT grown by Modified Vertical Bridgman – Yinnel Tech

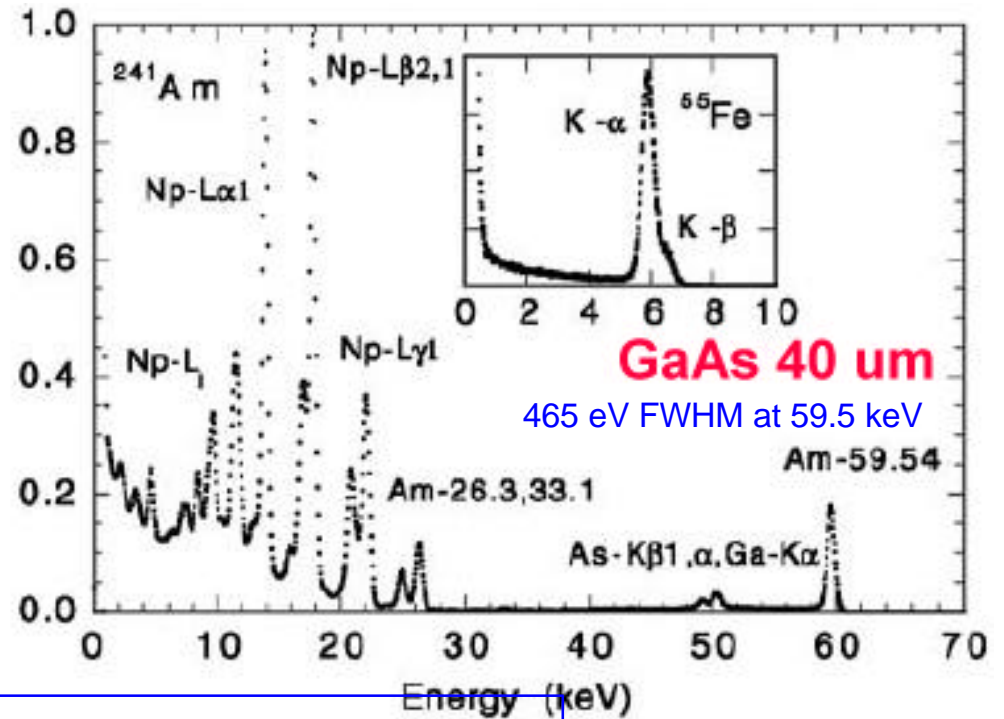
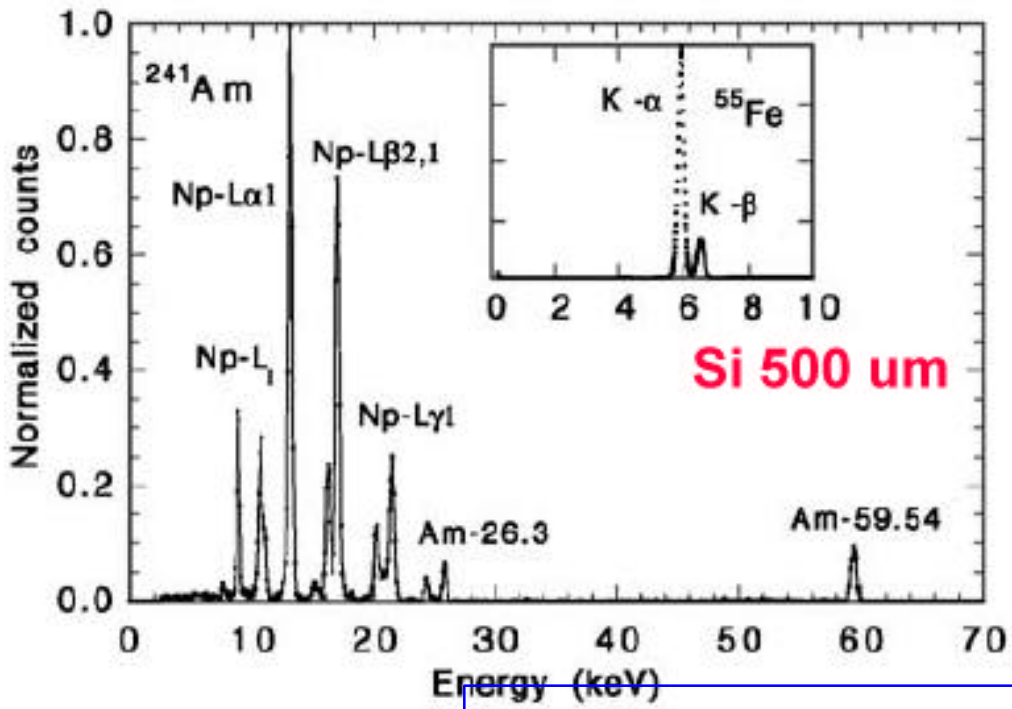
Modified Vertical Bridgman (MVD) CZT has been produced by Yinnel Tech

- ❑ wafers of large single-crystal areas are claimed, with excellent charge transport
- ❑ High resistivity  $\rho=3 \times 10^{11} \Omega \text{cm}$ , and  $\mu\tau_e=1.8 \times 10^{-2} \text{ cm}^2/\text{V}$

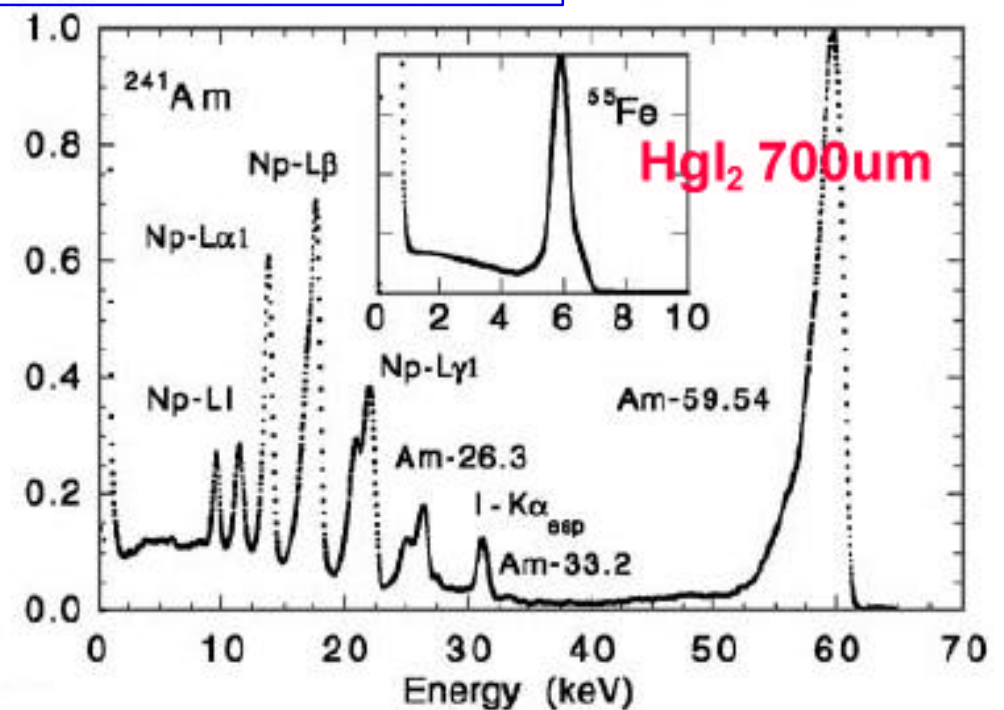
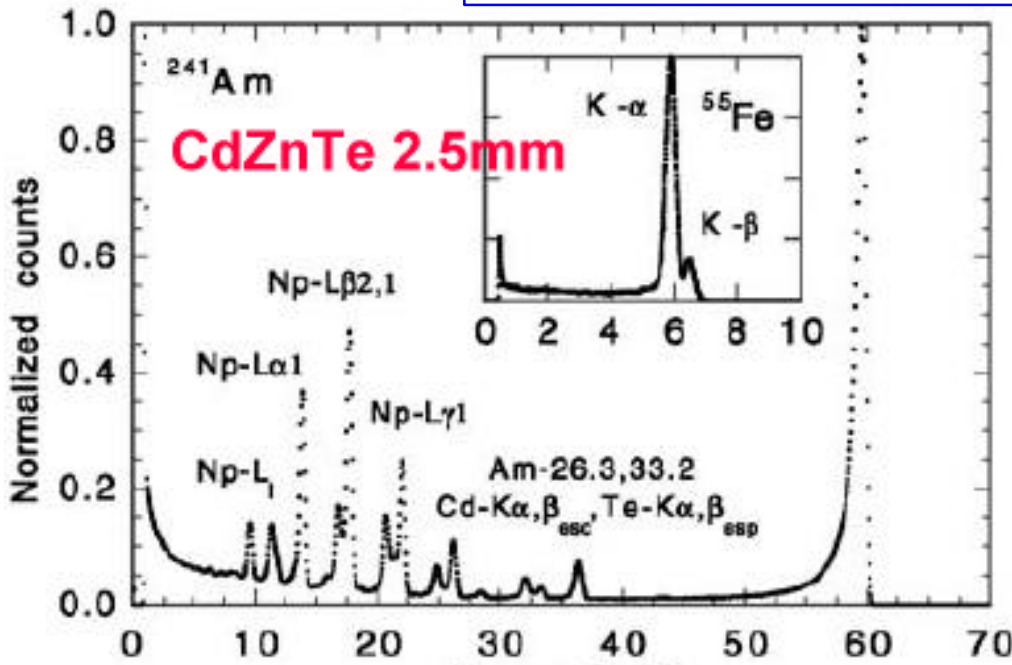


4x4 pixellated devices  
have shown very good  
resolution  
 $\Rightarrow$  1.35% FWHM at  
662 keV





Single element planar contact detectors





# CdTe and CdZnTe in space: INTEGRAL and SWIFT

IBIS is the gamma ray imager on INTEGRAL:

- ❑ fine angular resolution imaging (12 arcmin FWHM),
- ❑ spectral sensitivity, wide energy range (15 keV - 10 MeV)
- ❑ 16384 elements of 4x4x2mm CdTe, plus 4096 CsI, covering 3100 cm<sup>2</sup>

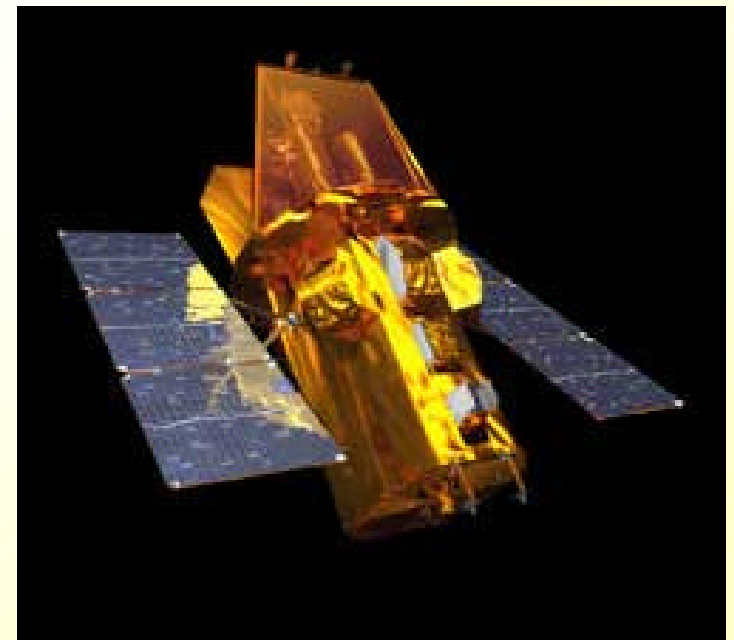
**INTEGRAL launched October 2002**



SWIFT Burst Alert Telescope (BAT) produces a first image within 10 seconds of the event trigger

- ❑ large imaging range (15-150 keV) using CZT, with additional response up to 500 keV
- ❑ 32768 elements of 4x4x2mm CZT, forming an array detector 1.2 x 0.6 m

**SWIFT launched November 2004**



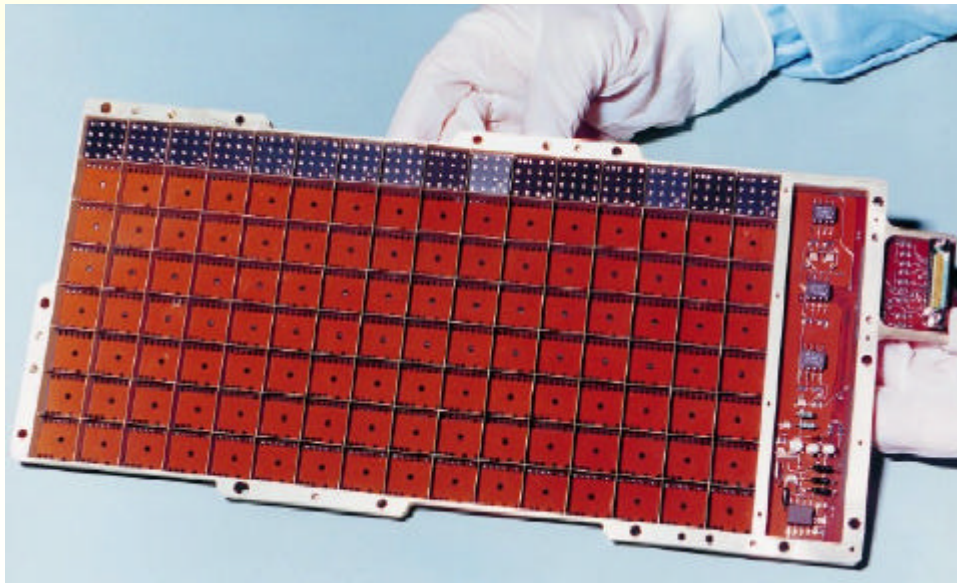
See talk by F. Lebrun,  
Tuesday afternoon:  
“Semiconductor  
detectors for soft  
gamma-ray  
astrophysics”

# Imaging detector modules

INTEGRAL CdTe detector array:

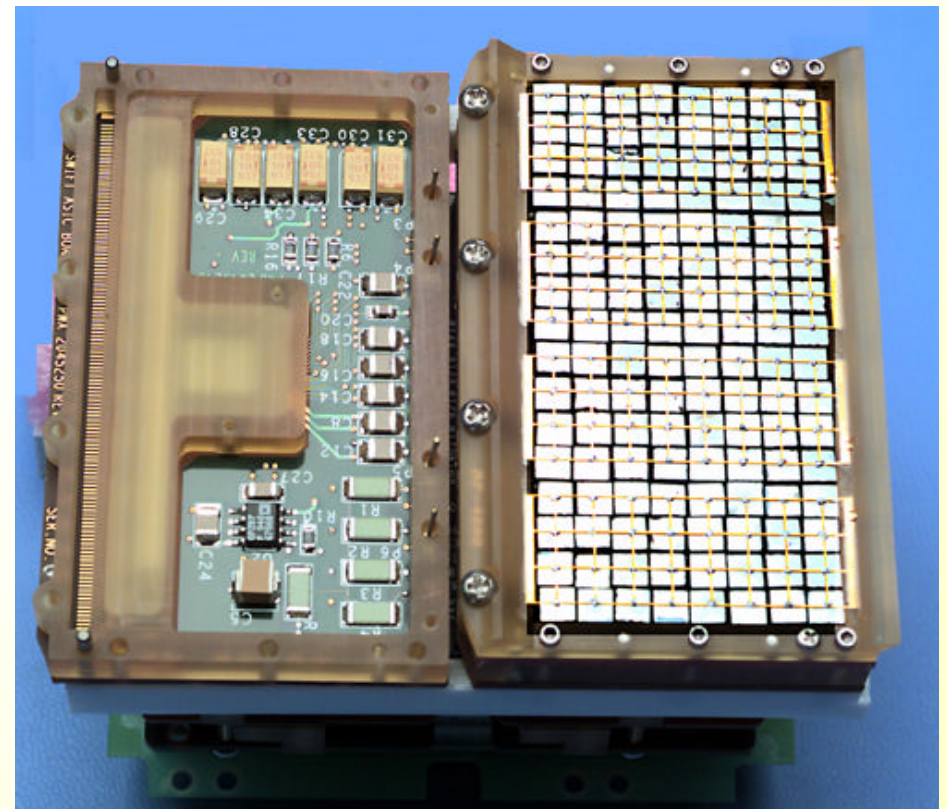
**2 parallel planes of pixels separated by 90 mm:**

- ❑ top layer uses 16384 CdTe pixels, covering 2600 cm<sup>2</sup>, each 4x4x2 mm ⇒ low energy gammas
- ❑ second layer uses 4096 CsI scintillators covering 3100 cm<sup>2</sup>, each 9x9x30 mm ⇒ high-energy gamma rays.



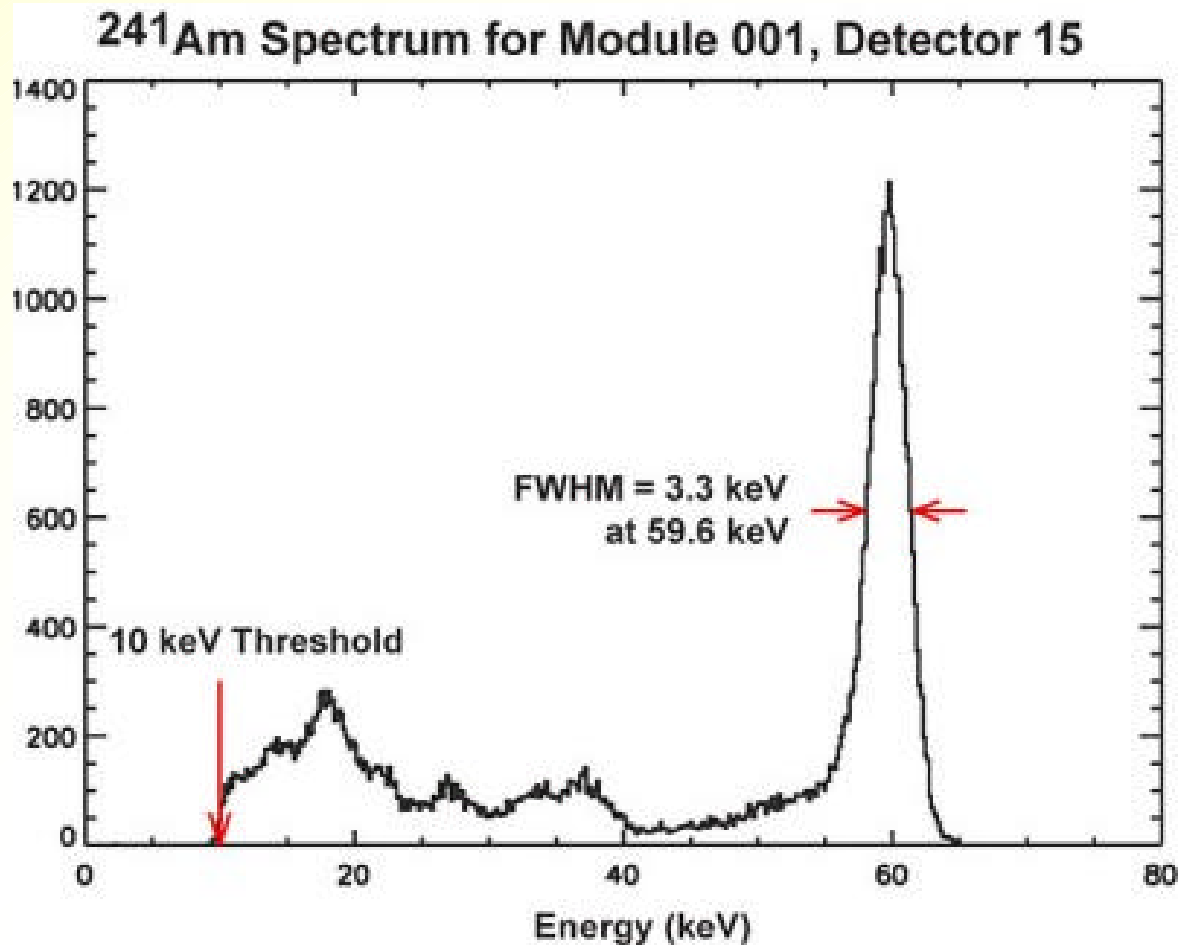
SWIFT CZT detector array:

- ❑ Contains 32768 elements of 4x4x2mm CZT, forming an array detector 1.2 x 0.6 m
- ❑ The coded aperture mask is ~54,000 lead tiles!



# CZT detector performance

The typical performance of a single CZT module is 3.3 keV FWHM at 60 keV (5.5% FWHM):

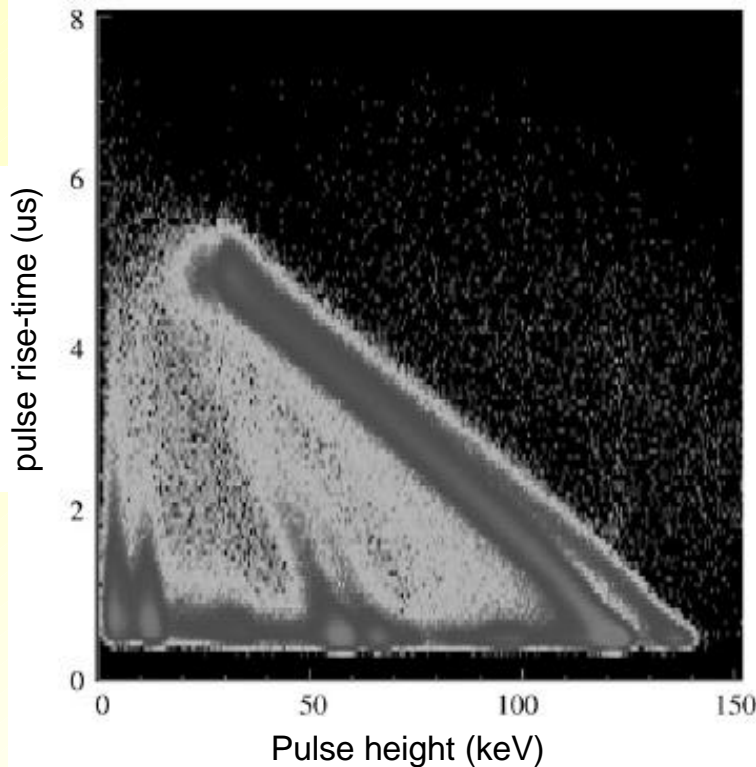


The background event rate in the CZT array is  $\sim 10$  kHz

# INTEGRAL CdTe spectroscopy

Pulse rise time correction applied to 2mm thick CdTe at 100V:

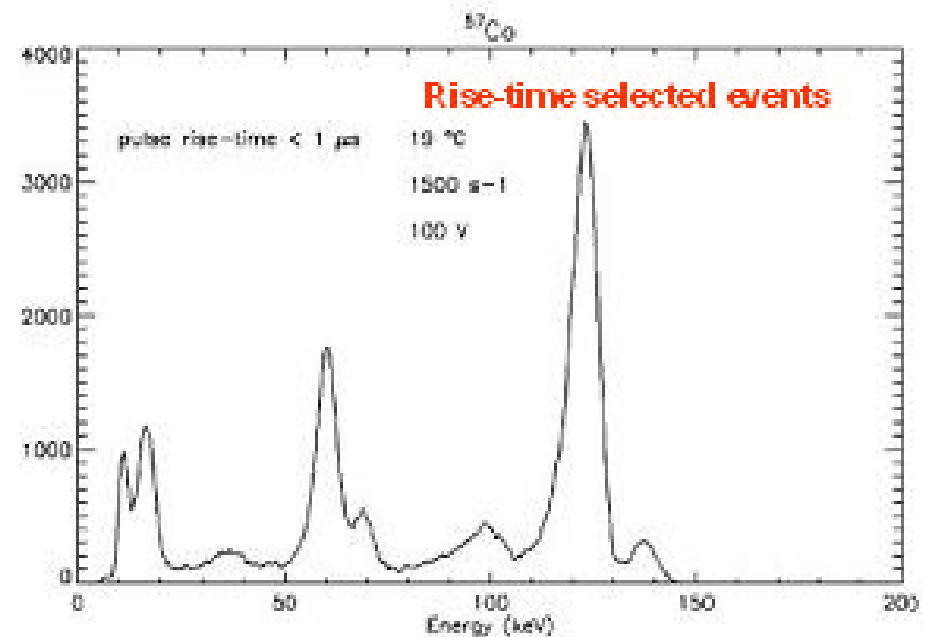
- uses simultaneous pulse rise time and amplitude measurements
- pulse drift time measures electron drift time to the anode, giving interaction depth
- correction for electron trapping improves total peak efficiency



O. Limousin et al, NIM A504 (2003) 24-37

Rise-time selected CdTe spectrum:

- In CdTe risetime selection is implemented on the ASIC to reject pulses with risetime  $>1 \mu\text{s}$
- CdTe energy resolution is 9.2 keV FWHM at 122 keV (7.5% FWHM)





# Thick film material developments

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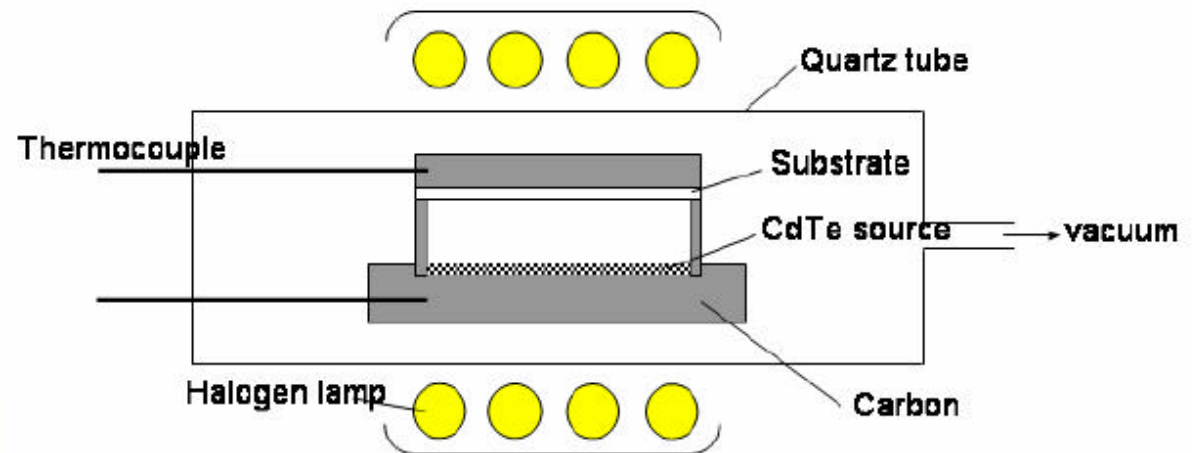
Growth of CdTe/CdZnTe as a large area thick-film has been developed extensively in Japan and Korea:

- ❑ Thick films deposited onto active substrates are required for medical imaging
  - avoids flip-chip bonding required for single-crystal wafers
- ❑ Polycrystalline films suffer from poor charge transport and low spectroscopic performance – grain boundaries act as:
  - sites for electron-hole recombination and trapping
  - charge scattering which reduces the mobility
  - local regions of disturbance to the applied electric field
- ❑ Recent results from:
  - Nagayoshi (Tokyo) - polycrystalline CdTe by Close Space Sublimation
  - Park (Seoul) – thermally evaporated polycrystalline CdZnTe
  - Tokuda (Shimadzu Co, Kyoto) – poly CdTe/CdZnTe by CSS
  - Niraula (Nagoya) – epitaxial CdTe films by Vapour Phase Epitaxy
- ❑ 59 keV photopeak observed from epitaxial CdTe material

# Large area CdTe by Close-Space sublimation

Close space sublimation (CSS) is a growth method capable of large area thick-film growth – recently applied to CdTe layers  $>300\mu\text{m}$  thick

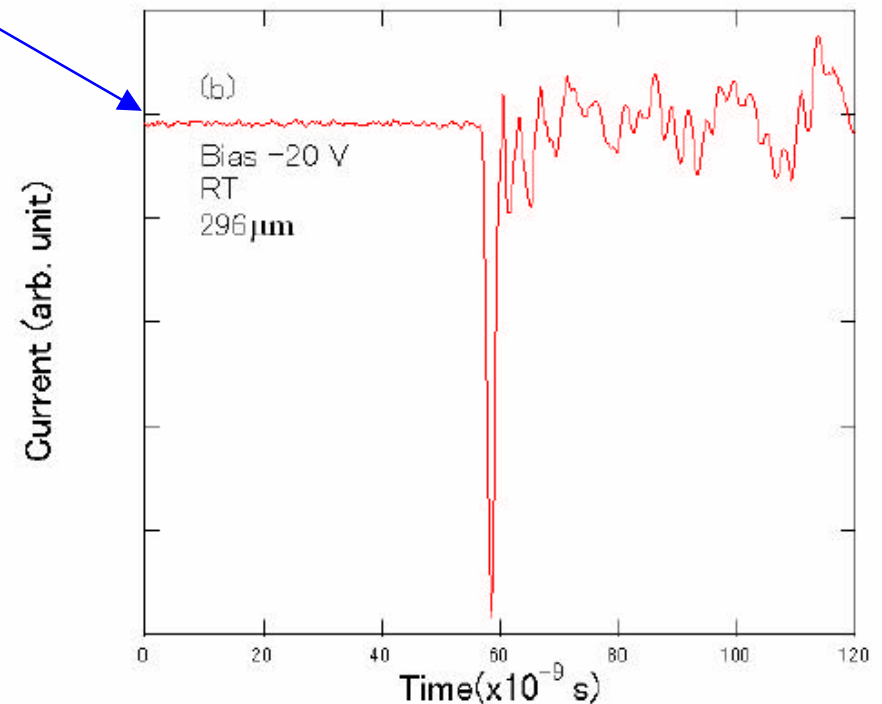
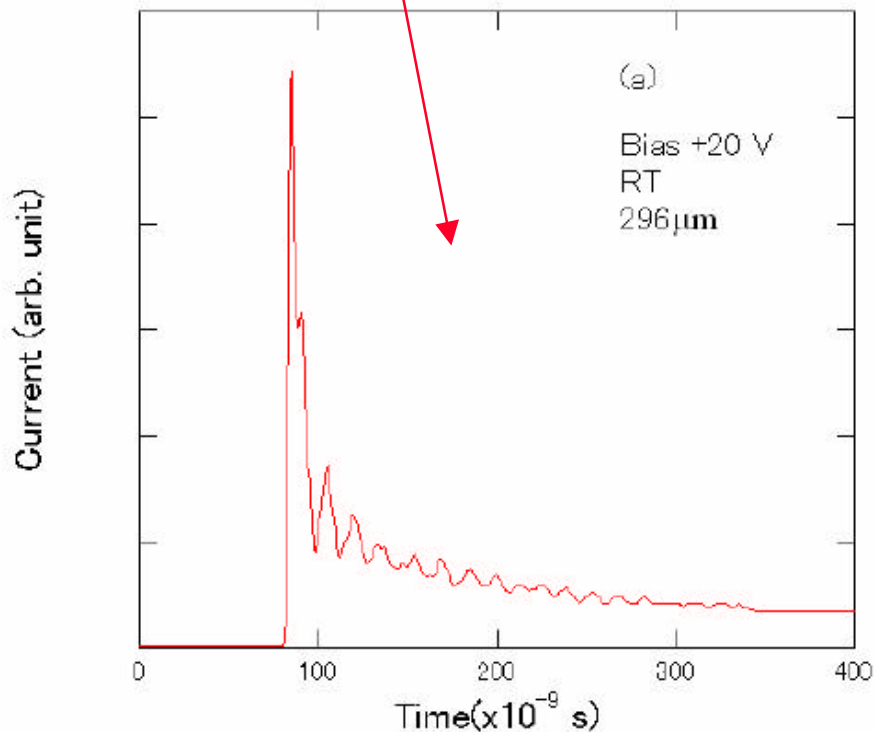
- ❑ CSS growth is one of the fastest thick-film techniques:  $5\text{-}10\ \mu\text{m}/\text{min}$
- ❑ Grown on quartz or glass substrate – thick film peels off to provide a free-standing ‘wafer’ – temperature  $440\text{--}550\ \text{°C}$
- ❑ Lightly p-type films with resistivity  $\sim 10^{10}\ \Omega\text{cm}$
- ❑ Typical crystallite sizes  $\sim 10\ \mu\text{m}$



# Photoresponse of CSS CdTe

Time of flight response using a 300ps nitrogen laser showed short carrier lifetimes:

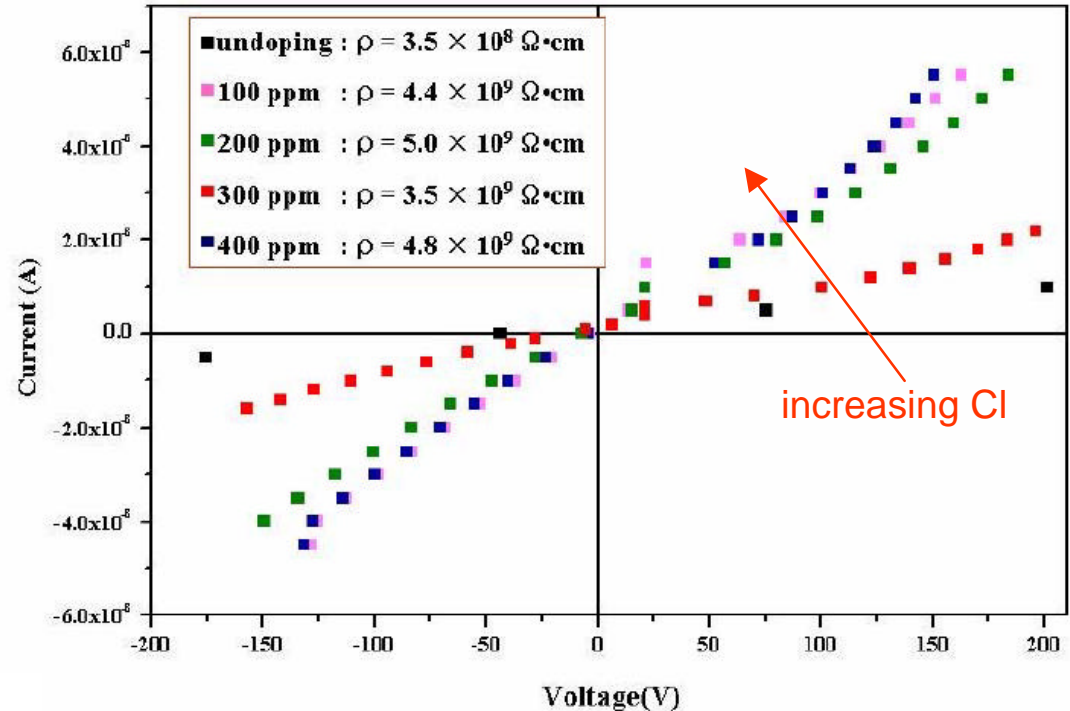
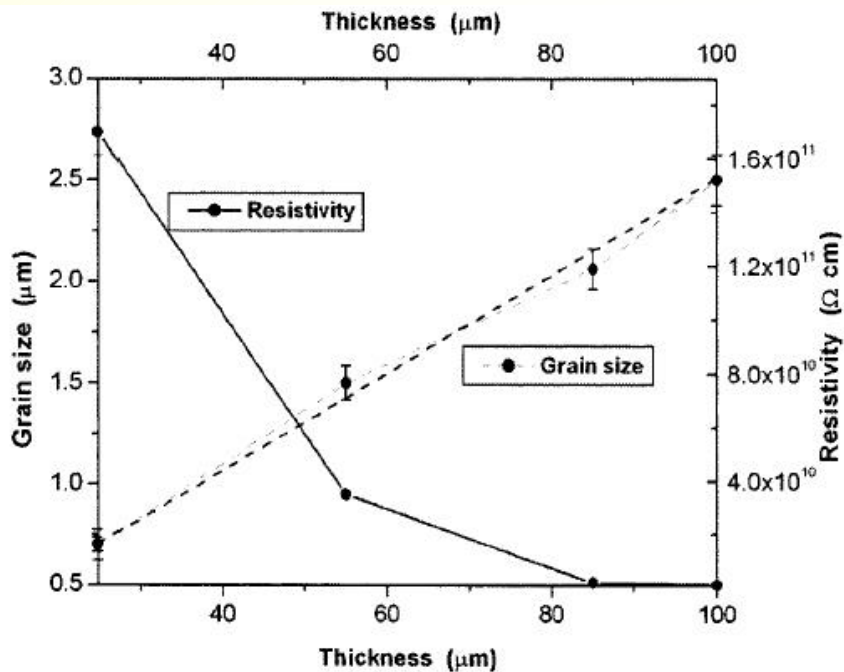
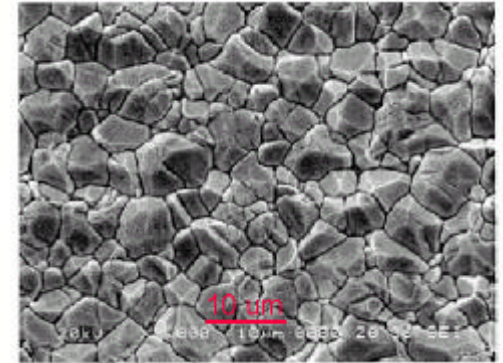
- ❑ For **anode irradiation** (hole transport) a prompt peak of <10ns is observed, followed by thermalisation:  $\Rightarrow$  shallow hole traps
- ❑ For **cathode irradiation** short lifetimes are also observed, with no thermal component:  $\Rightarrow$  deep electron traps
- ❑ No radiation response yet reported  $-\mu\tau$  values still very small



# Polycrystalline CdZnTe grown by thermal evaporation

CdZnTe films have been grown by thermal evaporation, to 100  $\mu\text{m}$  thickness:

- Using a source temperature of 700°C CdZnTe is evaporated onto an ITO/glass substrate at <200°C – compatible with TFT arrays
- Slower deposition rate than for CSS method, <2  $\mu\text{m/hr}$
- Grain sizes are  $\sim 2 \mu\text{m}$ , with  $\rho = 10^9$  to  $10^{11} \Omega\text{cm}$
- Chlorine doping used to increase resistivity for large grain sizes



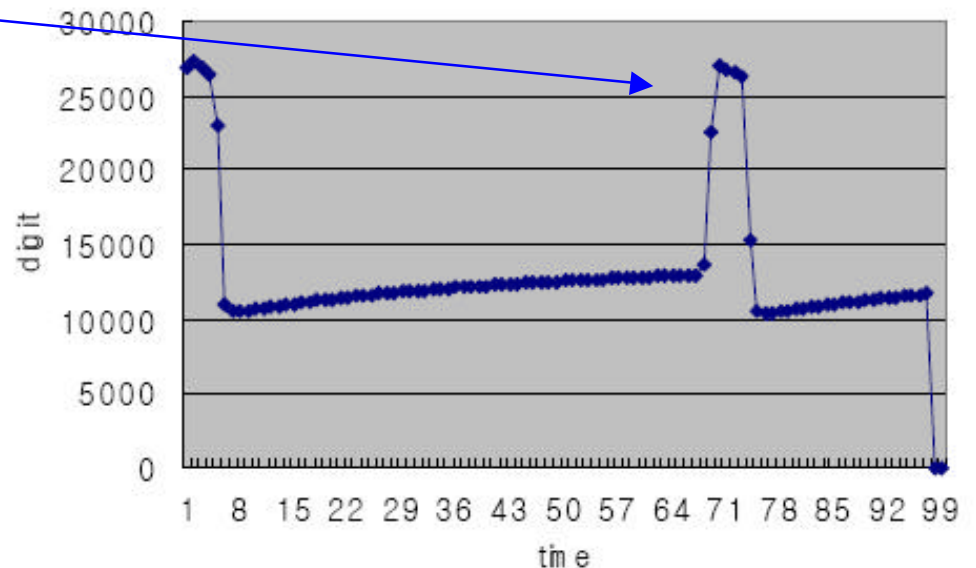
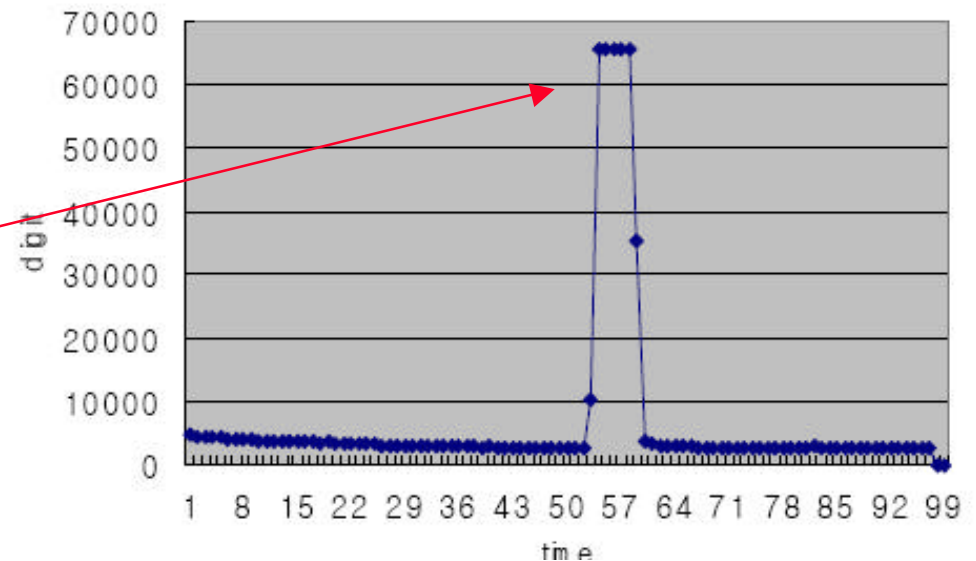


# X-ray response of polycrystalline CdZnTe

X-ray response of poly CdZnTe measured using a 65 kV<sub>p</sub> X-ray tube at 7.5 mA

Measuring DC photocurrents:

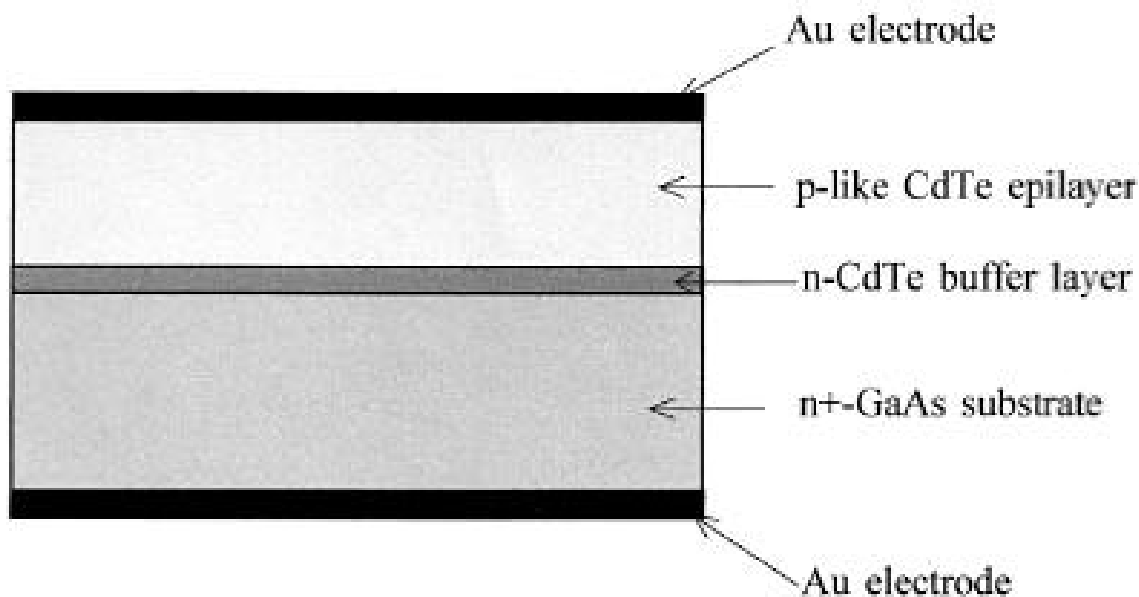
- ❑ **Single crystal CdZnTe:** signal amplitude saturated at 65,536 adc units
- ❑ **Polycrystalline CdZnTe:** signal amplitude ~14,000 adc units
- ❑ Polycrystalline material showed significant dark current and response to ambient light
- ❑ Non-stable dark current suggests thermal de-trapping of deep levels
- ❑ No single-pulse sensitivity demonstrated yet



# Large-area epitaxial CdTe grown by MOVPE

Metal-organic vapor-phase epitaxy (MOVPE) is capable of growing large-area epitaxial thick films, eg. up to 200  $\mu\text{m}$  thick

- ❑ MOVPE growth of CdTe or CdZnTe on GaAs or Si substrates, produces uniform mono-crystals
- ❑ GaAs substrates provide a good lattice match and strong adhesion



- ❑ Iodine-doped buffer layer grown onto substrate ( $10^{17} \text{ cm}^{-3}$ )

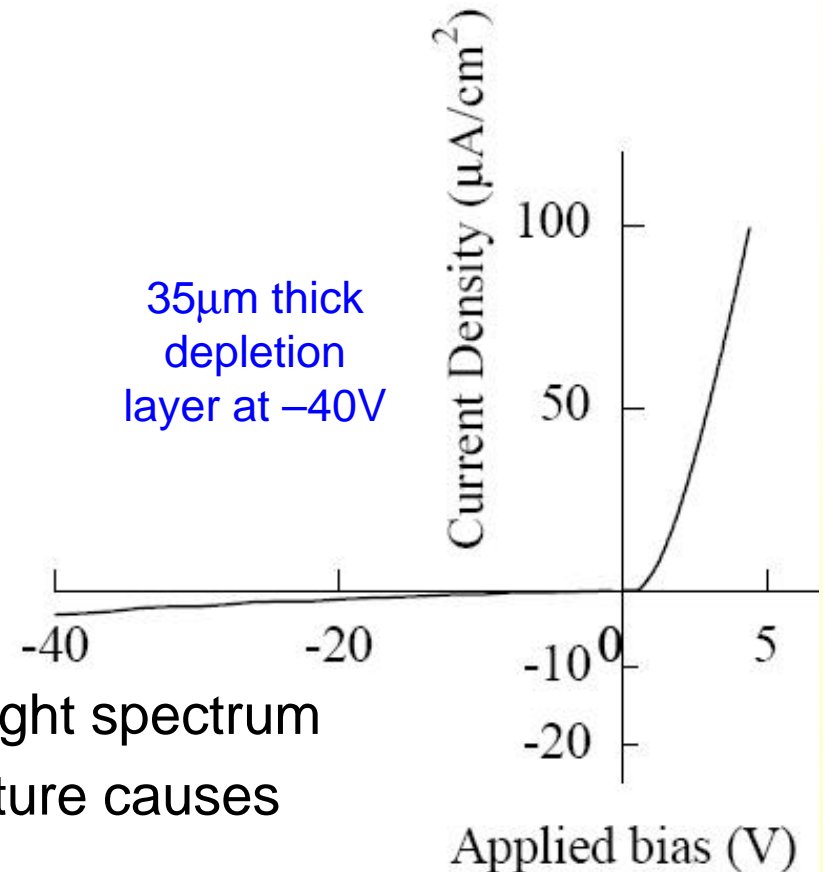
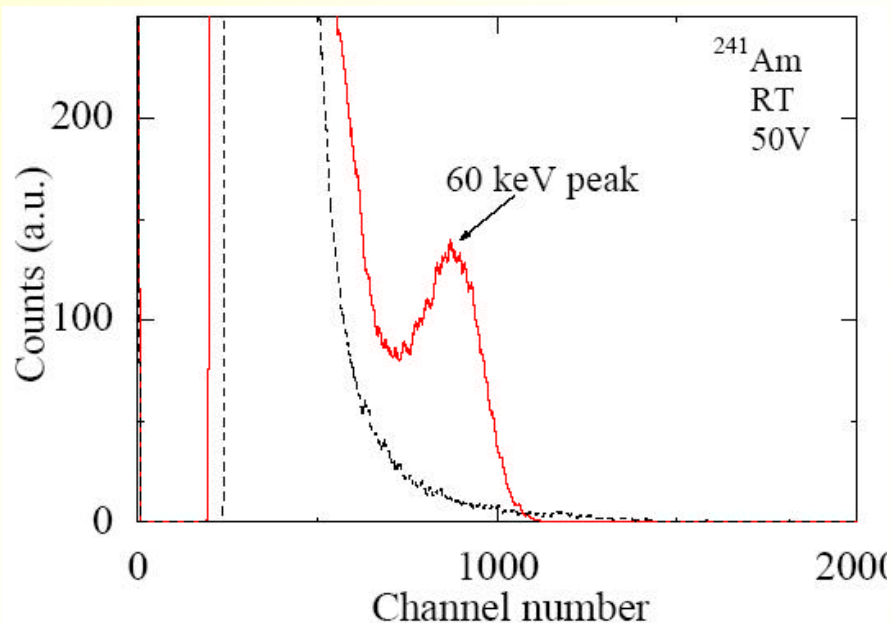
Prevents Ga diffusion into epitaxial CdTe layer

- ❑ undoped p-type epitaxial CdTe layer grown at 415-560  $^{\circ}\text{C}$

- ❑ rectifying p-n junction formed at the CdTe/GaAs interface

# Dark current and spectroscopy performance

- ❑ 100 $\mu\text{m}$  thick CdTe layer
- ❑ IV shows good rectification,  $\Rightarrow$  reverse current  $\sim 3 \times 10^{-6}$  A/cm $^2$
- ❑ CV measurements show carrier concentration of  $\sim 10^{14}$  cm $^{-3}$



- ❑ resolved 59 keV photopeak in pulse height spectrum
- ❑ Large leakage current at room temperature causes high noise level in the spectrum
- ❑ Adjustment of buffer layer thickness, and use of guard electrodes, required to reduce current

# High-Z polycrystalline materials (Hg, Tl, Pb, Bi)

Polycrystalline thick film high-Z ( $Z \geq 80$ ) materials have been extensively studied for X-ray imaging applications:

Material	Z	density	mobility	$E_G$	resistivity
<u>Iodides:</u>		$\text{g/cm}^3$	$\text{cm}^2/\text{Vs}$	eV	$\Omega\text{cm}$
HgI <sub>2</sub>	80/53	6.4	50	2.1	$10^{13}$
PbI <sub>2</sub>	82/53	6.2	53	2.5	$10^{12}$
BiI <sub>3</sub>	83/53	5.8	48	1.7	$10^{12}$
<u>Bromides:</u>					
TlBr	81/35	7.6	75	2.7	$10^{12}$
PbBr	82/35	-	-	2.5-3.1	-
<u>Oxides:</u>					
PbO	82/8	9.5	-	1.9	-

The iodide and bromide families have many suitable candidates:

- Detailed studies of HgI<sub>2</sub> and PbI<sub>2</sub> have been carried out
- HgI<sub>2</sub> shows superior dark current and charge transport properties
- Promising results from TlBr, also as single crystal material



# Polycrystalline Mercuric Iodide

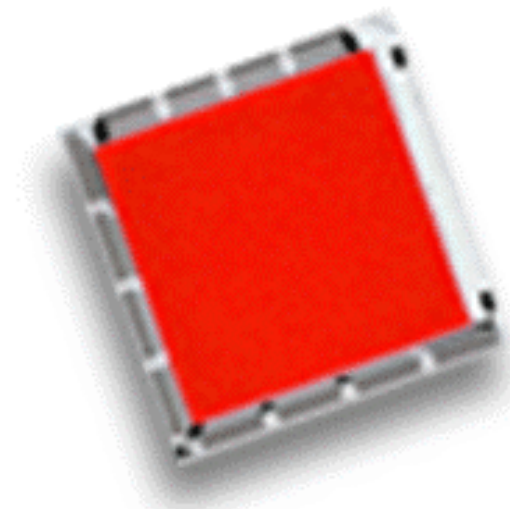
Polycrystalline  $\text{HgI}_2$  is a material receiving new interest – provides a thick-film X-ray Photoconductor coating for Thin Film Transistor (TFT) arrays:

- ❑ Extremely high X-ray Sensitivity
- ❑ Direct Conversion - no scintillators required
- ❑ Large area thick film technology (physical vapour deposition, or polymer binder) – compatible with TFT arrays for flat panel digital X-ray imaging detectors

single crystal  $\text{HgI}_2$



[www.realtimeradiography.com](http://www.realtimeradiography.com)



Application areas:

- ❑ Fluoroscopic and Conventional Radiography modes
- ❑ CT, security and industrial applications

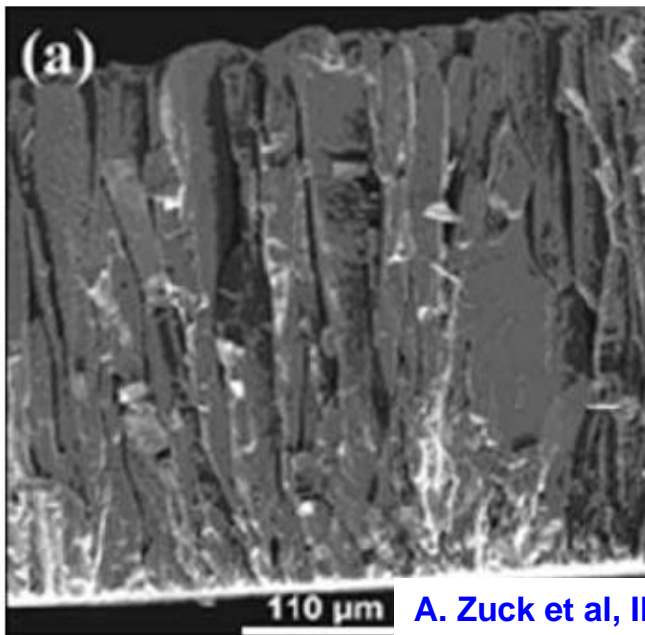
# Crystalline quality of HgI<sub>2</sub> films

Very high quality films, grown by Real-Time Radiography Inc  
Columnar structure, typically 80 $\mu$ m long, growing from the substrate surface

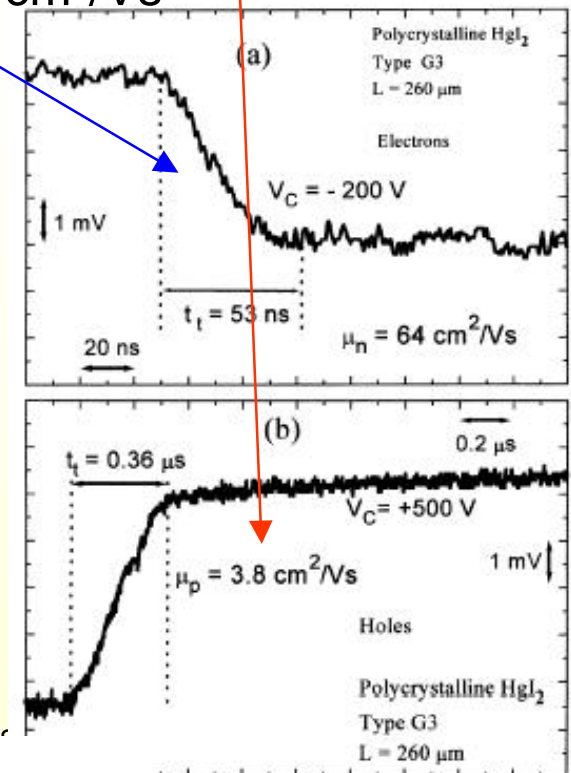
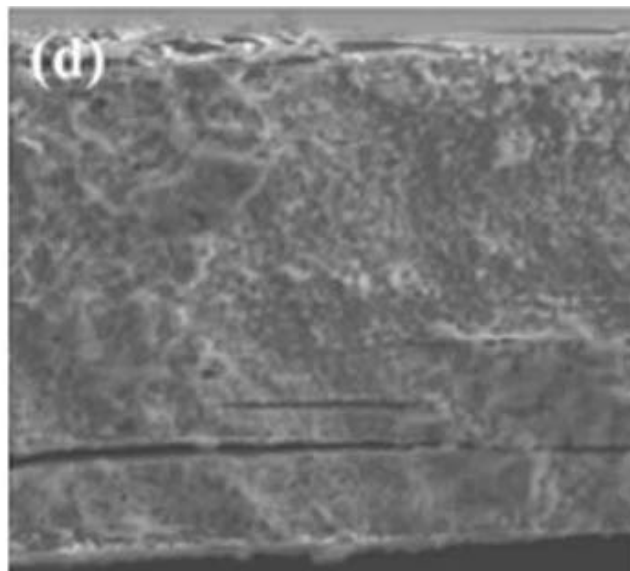
Well-defined alpha pulses show no significant charge trapping, and mobility values comparable with single crystals:

- best polycrystalline values:  $\mu_e \sim 87 \text{ cm}^2/\text{Vs}$  and  $\mu_h \sim 4 \text{ cm}^2/\text{Vs}$
- typical single crystal:  $\mu_e \sim 93 \text{ cm}^2/\text{Vs}$  and  $\mu_h \sim 5 \text{ cm}^2/\text{Vs}$

Polycrystalline HgI<sub>2</sub> layer

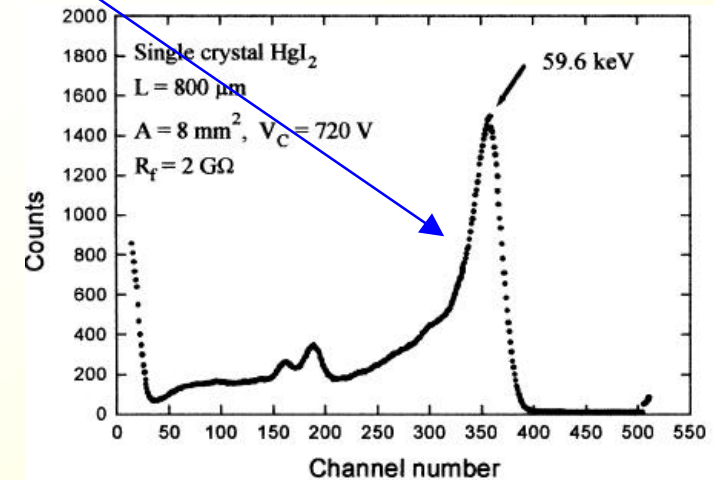
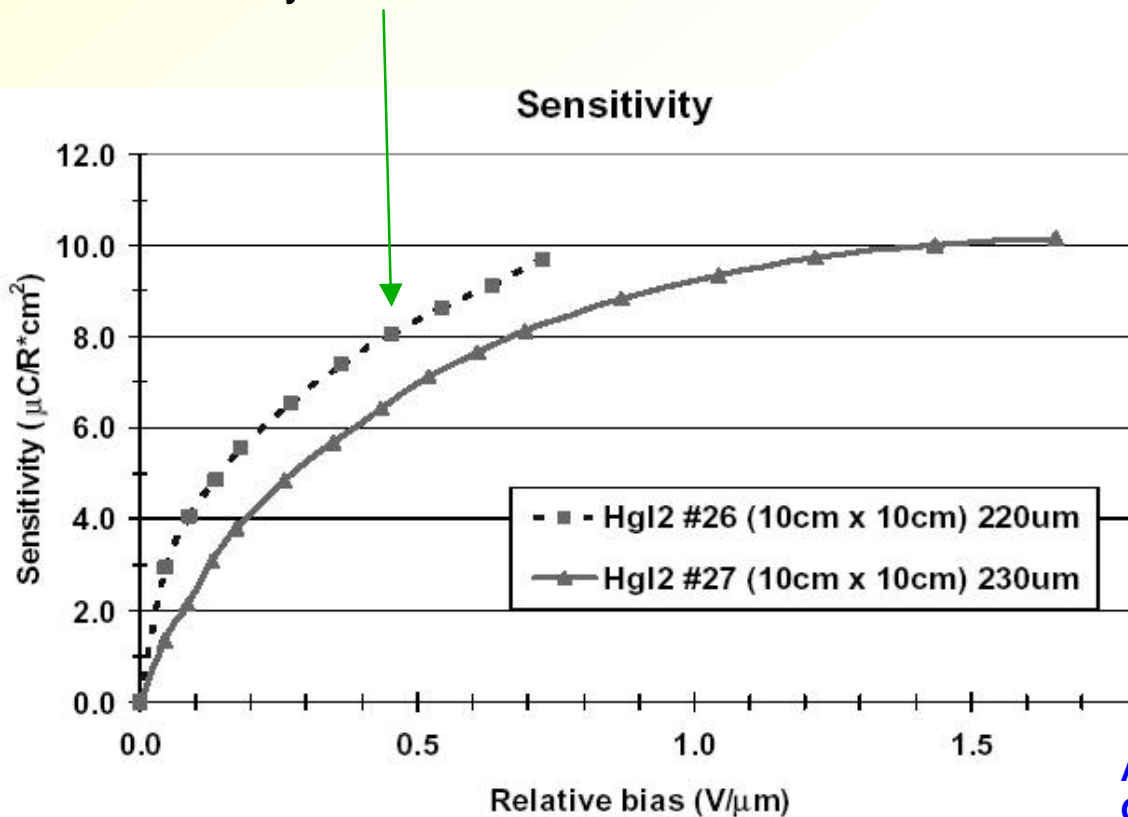
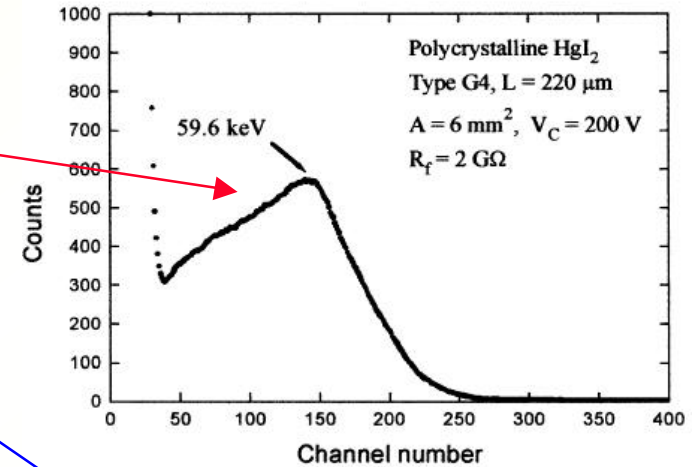


Single crystal HgI<sub>2</sub>



# Radiation response of HgI<sub>2</sub>

- ❑ Best **polycrystalline HgI<sub>2</sub> film** alpha particle response shows a broad full-energy peak
- ❑ Not as good as **single crystal HgI<sub>2</sub>**
- ❑ Low dark current, 24 pA/mm<sup>2</sup> @ 0.7 V/μm
- ❑ **High sensitivity**, up to 10 μCi/Rcm<sup>-2</sup> without early saturation

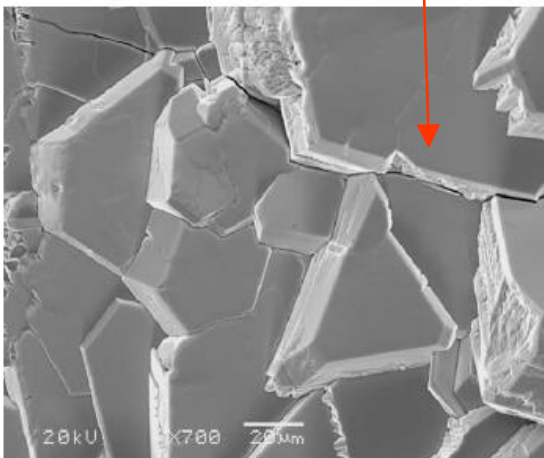


A. Zuck et al, IEEE Trans Nucl Sci 51 (2004) 1250-1255  
 G. Zentai et al, Proc SPIE-MI (2004) 5368-23

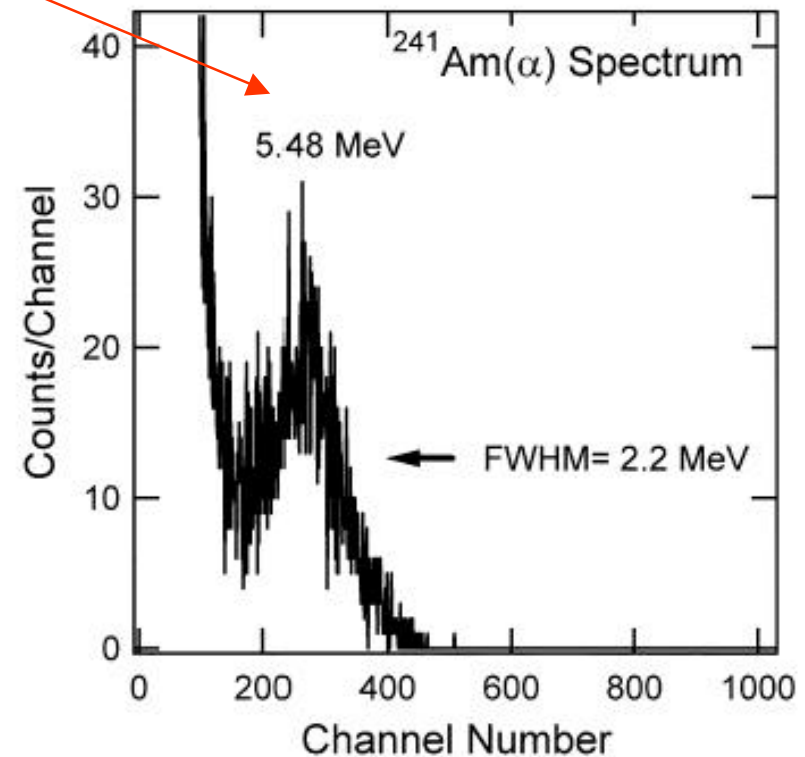
# Bismuth Tri-iodide

$\text{BiI}_3$  offers a good range of properties for X-ray detection, with  $Z_{\text{Bi}}=83$  and  $Z_{\text{I}}=53$ . Detector response has been reported from:

- ❑ Single crystal  $\text{BiI}_3$  grown by Bridgman methods
- ❑  $\text{BiI}_3$  platelets by vapour deposition ( $\sim 10\text{-}20\text{mm}^2$ ,  $50\text{-}80\mu\text{m}$  thick)
- ❑ Polycrystalline growth at low temperature ( $150^\circ\text{C}$ ) with  $\sim 50\mu\text{m}$  crystallites and film thickness of up to  $130\mu\text{m}$



- ❑ Charge transport worse than  $\text{HgI}_2$ ,  
 $\text{PbI}_2$ :  $\mu_e \sim 10 \text{ cm}^2/\text{Vs}$

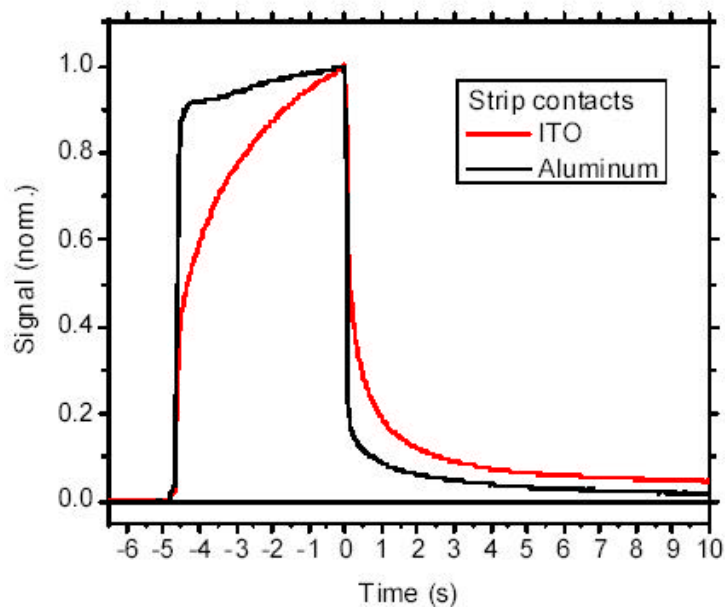
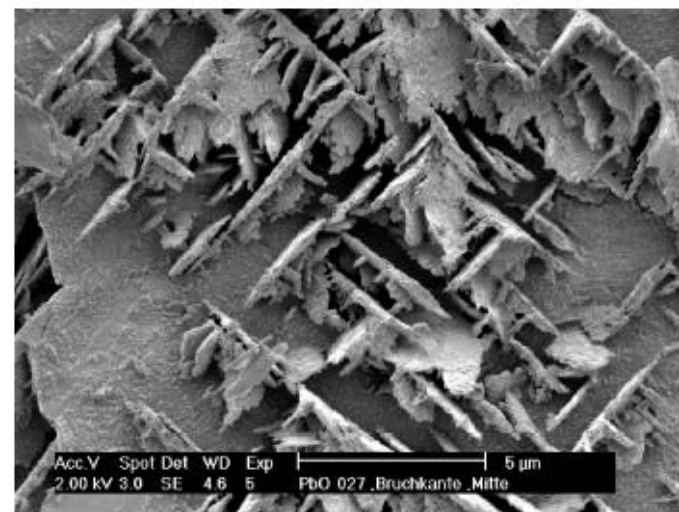




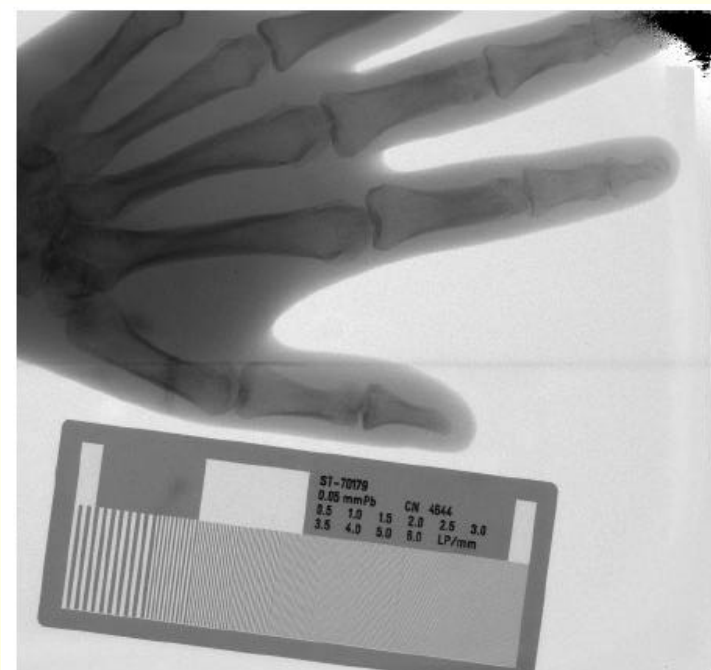
# Lead Oxide films

Thick film polycrystalline PbO films have been studied by Philips Research:

- ❑ Thermal evaporation process (100°C) for 25x25cm films, with 300µm thickness
- ❑ Thin platelet structure, 50% porous
- ❑ Low charge transport ( $\mu\tau_e \sim 4 \times 10^{-7} \text{ cm}^2/\text{V}$ ) but low dark current  $\sim 200 \text{ pA/mm}^2$
- ❑ X-ray temporal response dependent on contact structure



PbO prototype imager uses 18x20cm film on 960x1080 TFT pixel matrix  
160µm thick PbO film, 70kVp X-rays



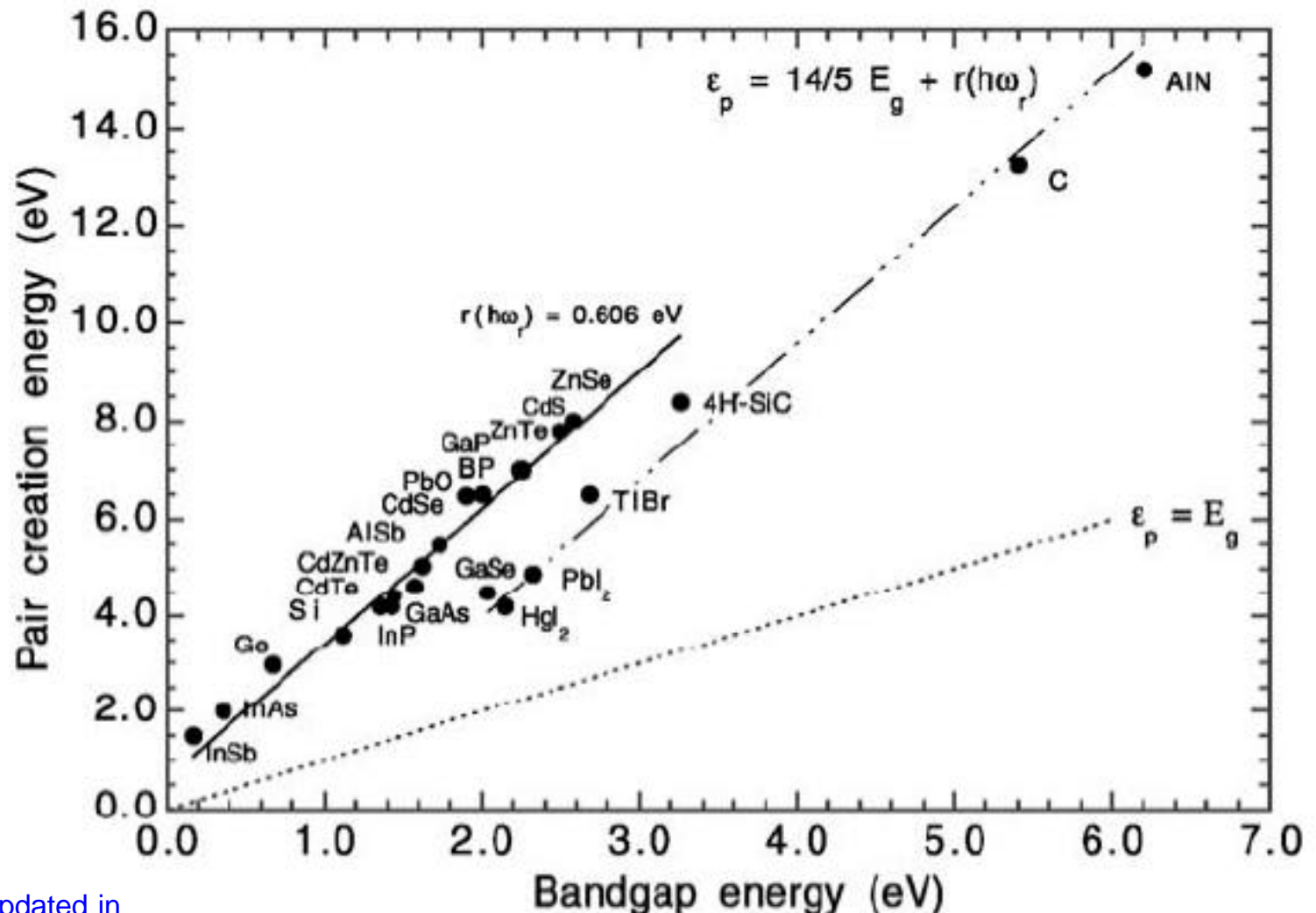
M. Simon et al, IEEE Trans Nucl Sci, in press

# New crystalline materials

The Klein chart shows the relationship between **ehp creation energy** and **bandgap**:

Here we consider  
3 possible new  
materials:

1. CdMnTe
2. GaN
3. Diamond



# CdMnTe – a future alternative to CdZnTe?

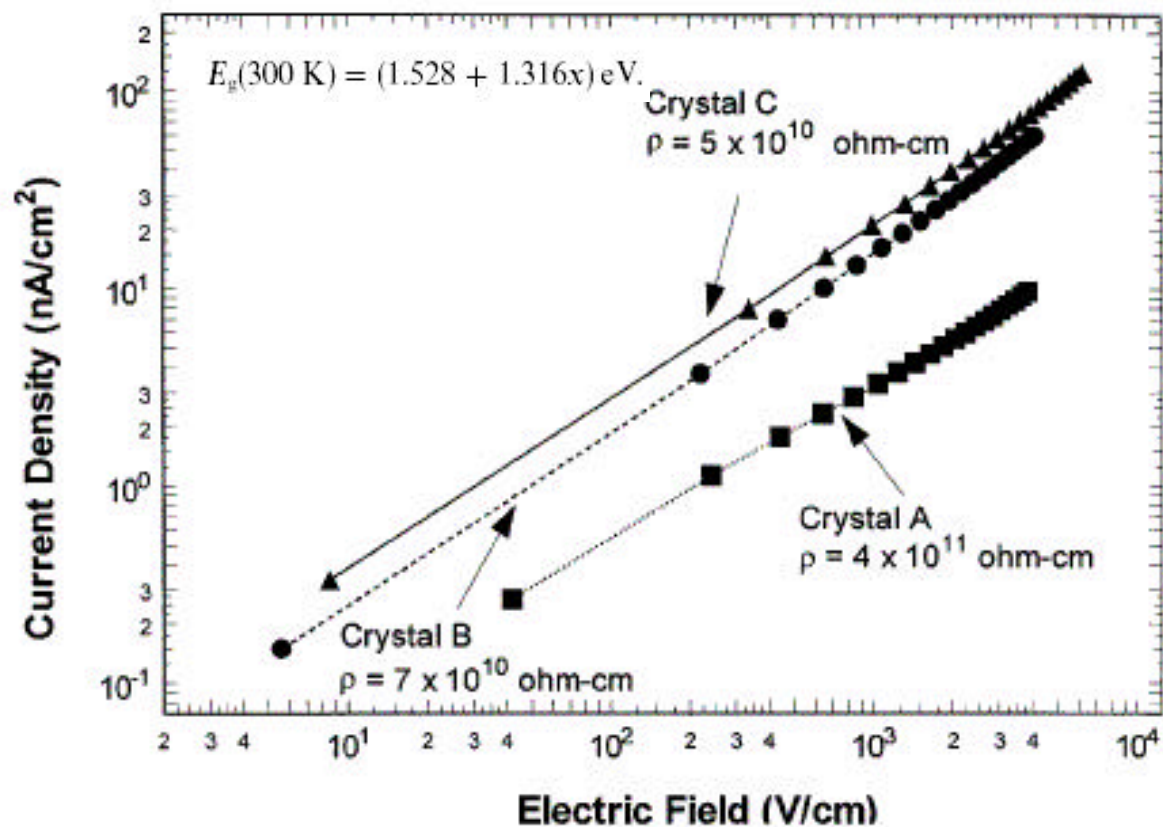
CdMnTe is a ternary alloy similar to CdZnTe – very low segregation coefficient of Mn should produce uniform crystals

- alloying with Mn increases the bandgap twice as fast as Zn (13 meV per % Mn)

- compensation using Vanadium or Indium doping achieves high resistivity

- bandgap values of 1.73 - 2.12 eV (CZT ~ 1.55 eV)

Growth of high resistivity crystals by the Vertical Bridgman technique has been demonstrated



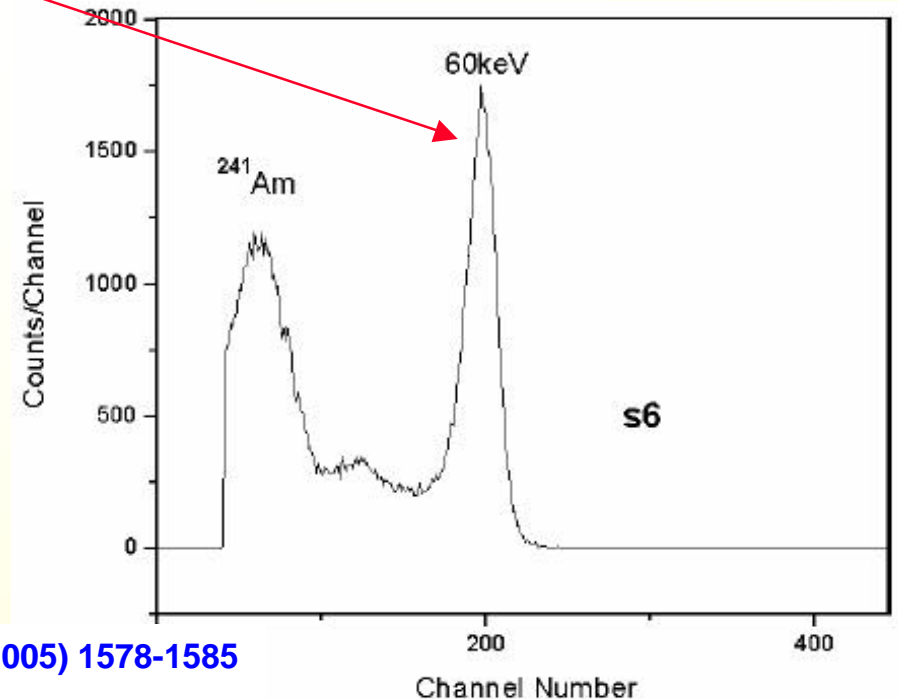
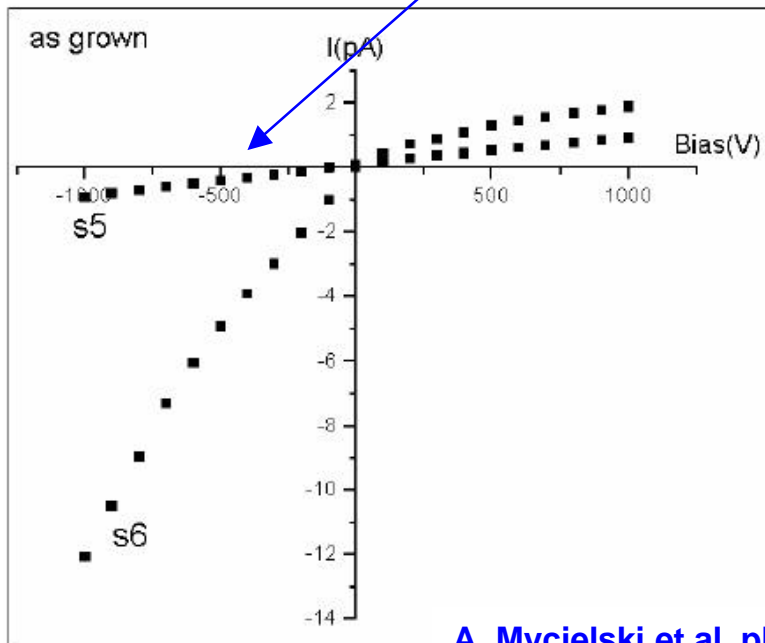
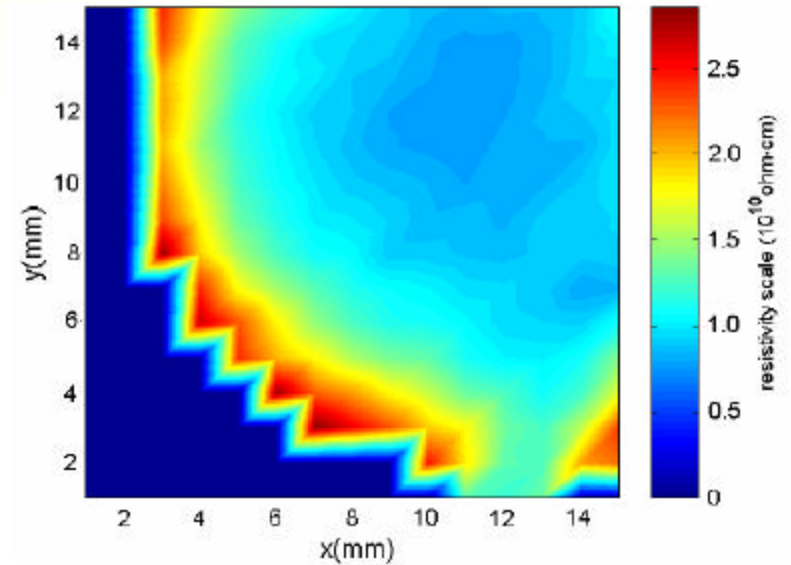
# First results from CdMnTe detectors

As-grown undoped CdMnTe is p-type: doping with indium has demonstrated  $\rho \sim 10^{11} \Omega\text{cm}$

Material quality currently limited by poor "4N" quality of manganese

Reasonable charge transport observed –  $\mu\tau_e \sim 2 \times 10^{-5} \text{ cm}^2/\text{V}$

Resolved photopeak observed at 59 keV



A. Mycielski et al, phys stat sol (c) 2 (2005) 1578-1585

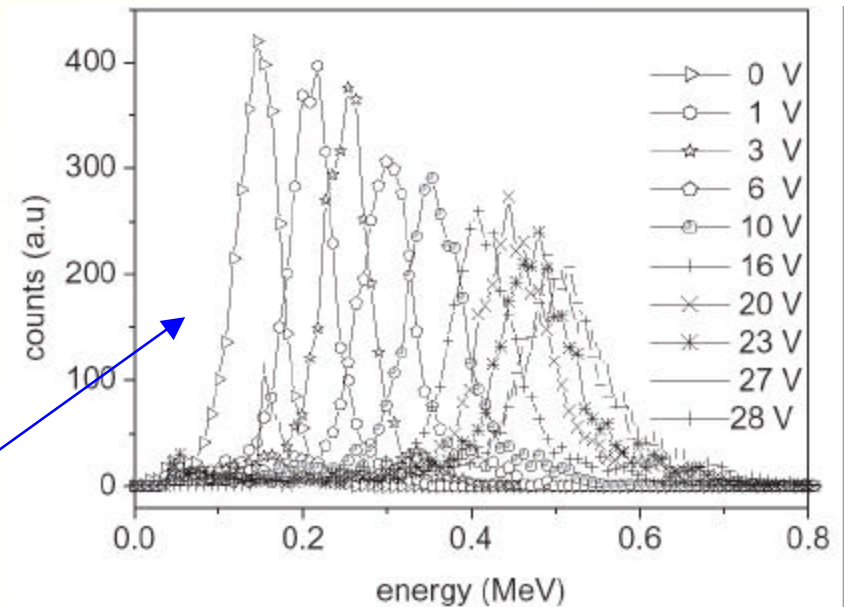
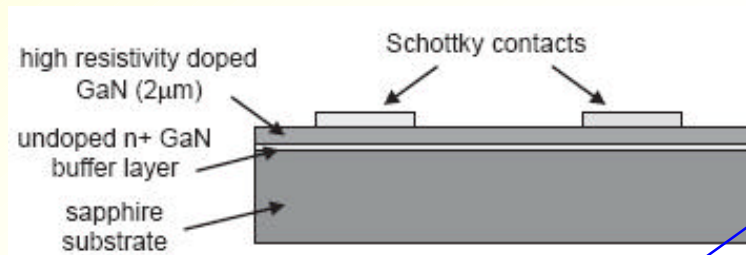


# GaN radiation detectors

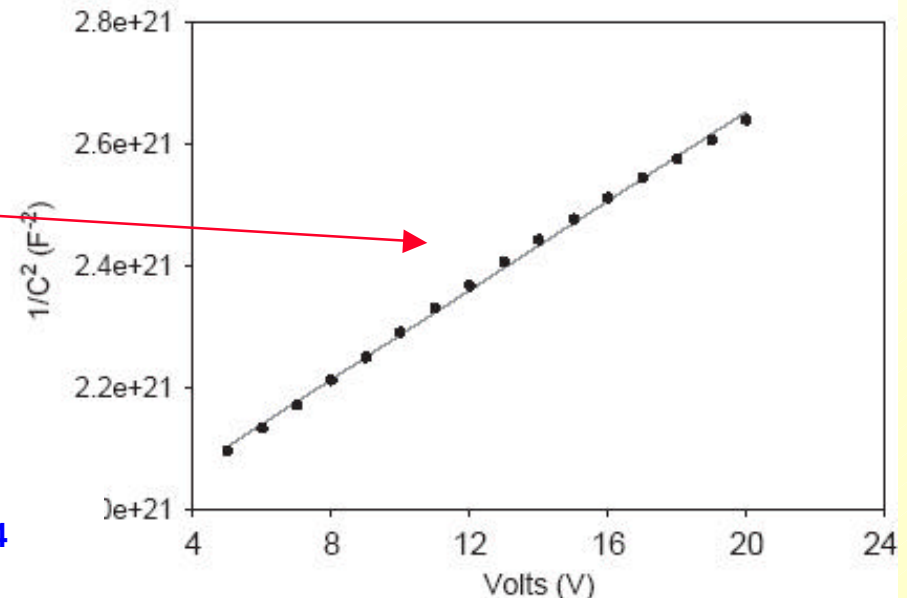
GaN (Z=31/7) is a candidate material for 20-60 keV X-ray detection

- Band gap is 3.39 eV
- Ehp creation energy is 8.9 eV/ehp

Thin epi-layers are grown onto sapphire:

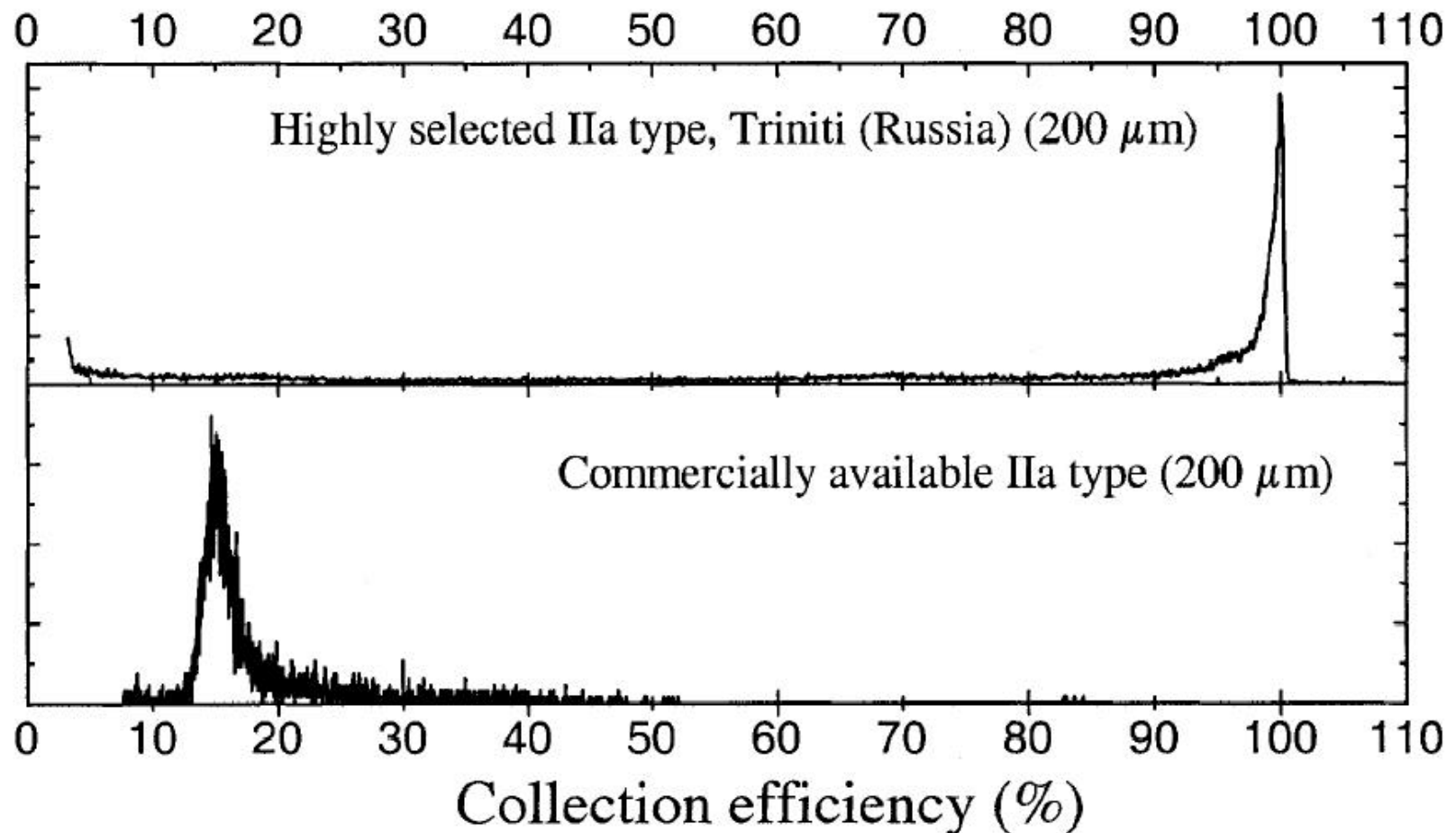


- Good **alpha particle response** has been seen in thin (2µm) epi layers
- CV data** gives carrier concentration of  $1 \times 10^{15} \text{cm}^{-3}$
- Free-standing thick (>100µm) GaN layers are now available, grown by High Pressure Vapour Exptaxy



# Single-crystal synthetic diamond

**Single-crystal natural diamonds** have been studied in the past for detector applications – not a viable option.



# High purity single-crystal synthetic diamond

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Companies in the US and UK have recently new growth techniques to fabricate near-perfect single-crystal artificial diamond

Primarily marketed as gem stones, diamond wafers 10x10mm are now available for device applications, with thickness of up to 500 $\mu$ m

*Image removed*

## 5x5mm piece of single-crystal synthetic diamond

Photoluminescence image shows real colour:

- HPHT substrate – yellow
- Nitrogen impurities – red
- Dislocations – cyan blue

# Single-crystal CVD diamond detectors

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Specialist applications of diamond detectors:

- ❑ as tissue-equivalent rad-hard detectors, eg megavoltage therapy beams
- ❑ detectors for very high temperature, high radiation environments

True single-crystal material  
removes charge trapping  
associated with grain  
boundaries:

- ❑ 100% CCE demonstrated from alpha particles
- ❑ High mobility  $\Rightarrow$  fast signals
- ❑ Radiation hardness tests are in progress

*Image removed*



# Conclusions

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- ❑ The demand for high-Z semiconductor radiation imaging detectors continues to develop, with potential applications in medical, synchrotron, space and security imaging
- ❑ CdZnTe continues to dominate the commercial supply of high-Z materials, with new suppliers of detector-grade material slowly becoming available
- ❑ There is a steady improvement in CdZnTe material uniformity, single-crystal volume, and spectroscopic performance, with  $\mu\tau_e$  approaching  $10^{-2}$  cm<sup>2</sup>/Vs
- ❑ There is significant R&D activity in thick film materials, compatible with large-area imaging devices:
  - Polycrystalline and epitaxial CdTe/CdZnTe thick films
  - Various  $Z \geq 80$  compounds, with excellent imaging performance demonstrated by HgI<sub>2</sub>
- ❑ New materials continue to be developed, with examples illustrated from CdMnTe, GaAs and single-crystal synthetic diamond

